

A Thermally Actuated MEMS Viscosity Sensor

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Outline

- Motivation
- Viscosity

- MEMS viscometers
- Proposed thermally actuated MEMS viscometer
 - Operation principles
 - Design
 - Evaluation
 - Results

- Proposed work

Motivation

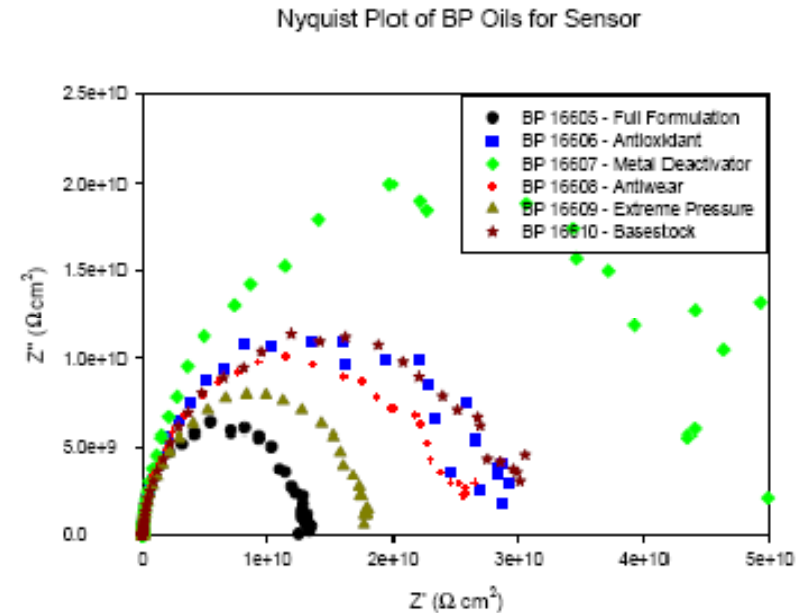
Fluid viscosity applications

- Automotive
 - Motor oil changes
 - Several factors determine when to change oil:
 - Contaminants, soot, water
 - Viscosity changes (shear, oxidation and soot)
 - Drive-train lubricants
- Medical
 - Blood coagulation rates (point-of-care treatment)
- Industrial

- Small, reliable and inexpensive -- MEMS

In-situ monitor of lubricant quality

- Multisensor diagnostics
- Contaminants
 - Water, soot
 - Electrochemical Impedance Spectroscopy (EIS)
- Viscosity and density
 - Both change as oil degrades over time
- Temperature and relative humidity sensors are also desired



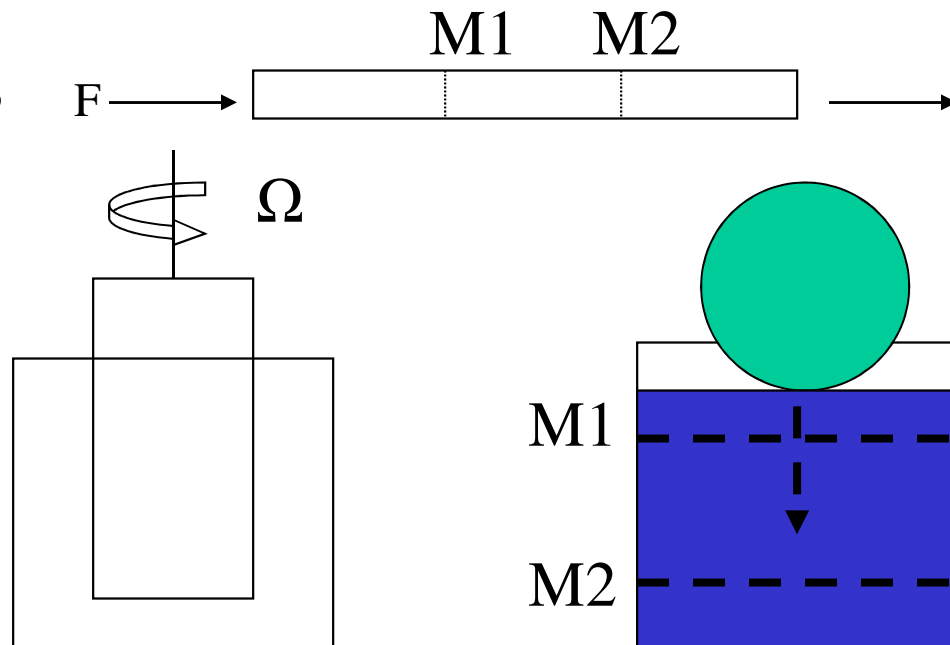
Marx et al, "Micro-Sensor for Monitoring Oils", IEEE 2006

Viscosity

- Viscosity
 - Internal resistance to flow or shear
 - Measured with a viscometer using a small sample of lubricant
 - In-situ measurement is desired

- Viscometer types

- Capillary
- Rotational
- Falling ball
- Vibration
- Ultrasonic
- others



Viscosity and oil viscosity

- Dynamic viscosity is measured in Pa*s or centiPoise

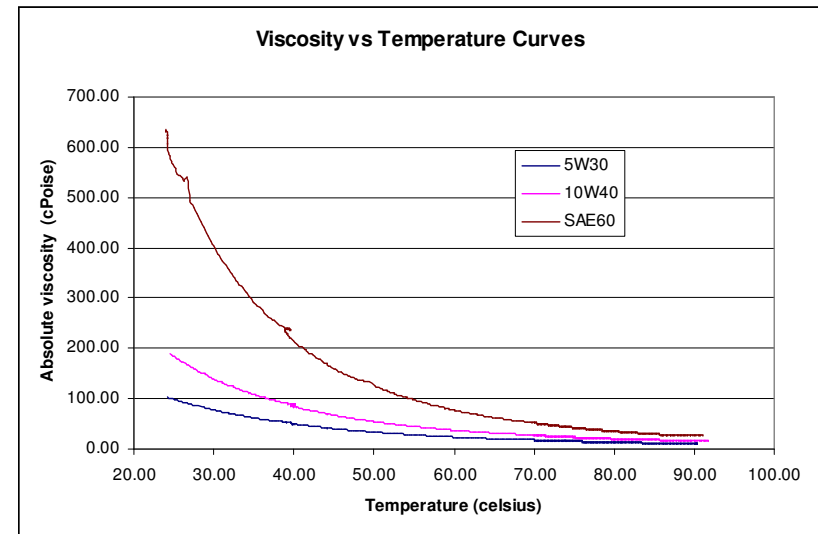
$$1 \text{ cP} = 0.001 \text{ Pa*s}$$

- Kinematic viscosity takes into account density of fluid

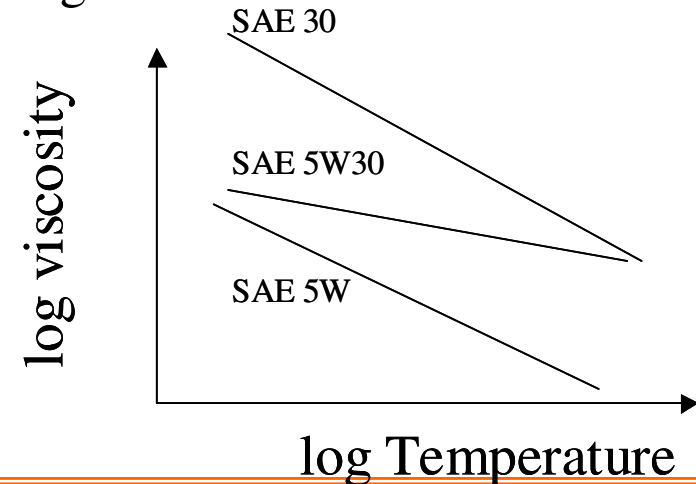
$$\nu = \frac{\eta}{\rho}$$

$$1 \text{ cSt} = 0.0001 \text{ m/s}^2$$

- Oil Viscosity depends on temperature

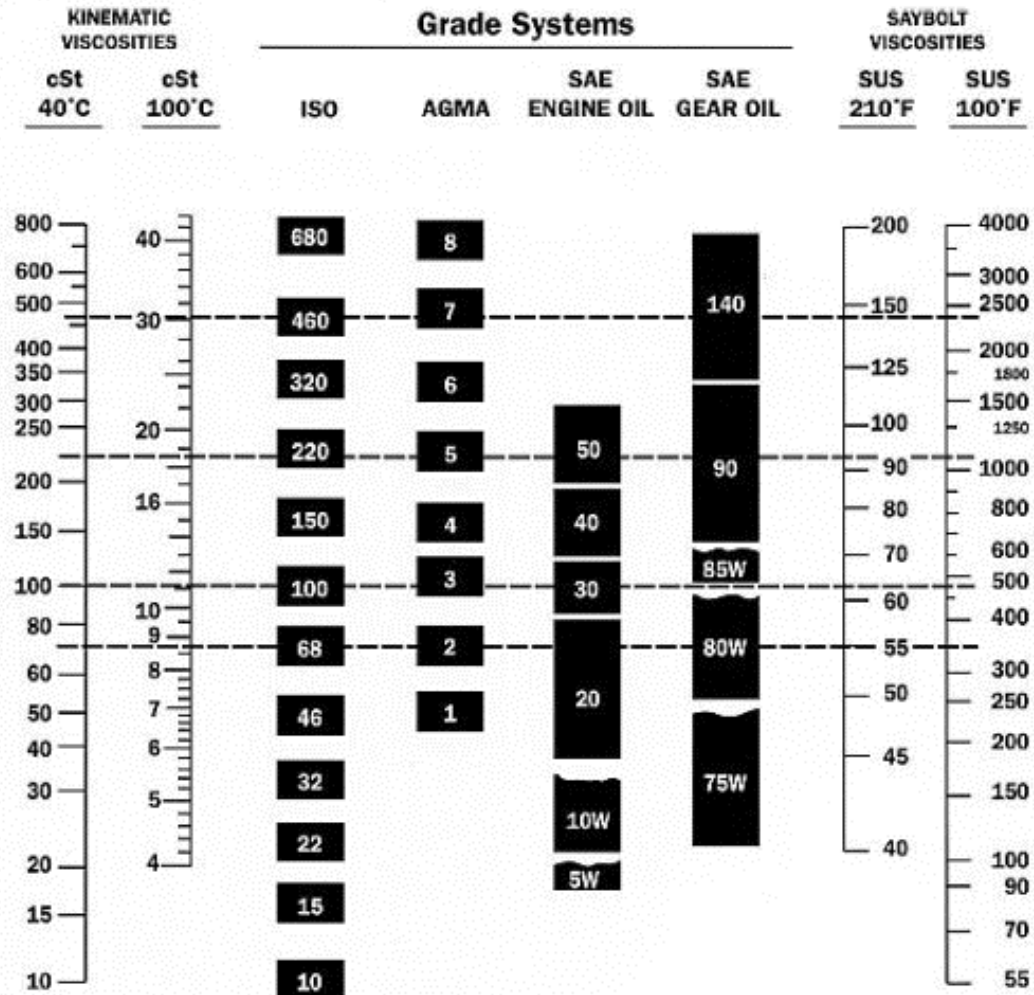


- Multigrade Oils



Stokes to SAE standard

www.widman.biz/uploads/Corvair_oil.pdf



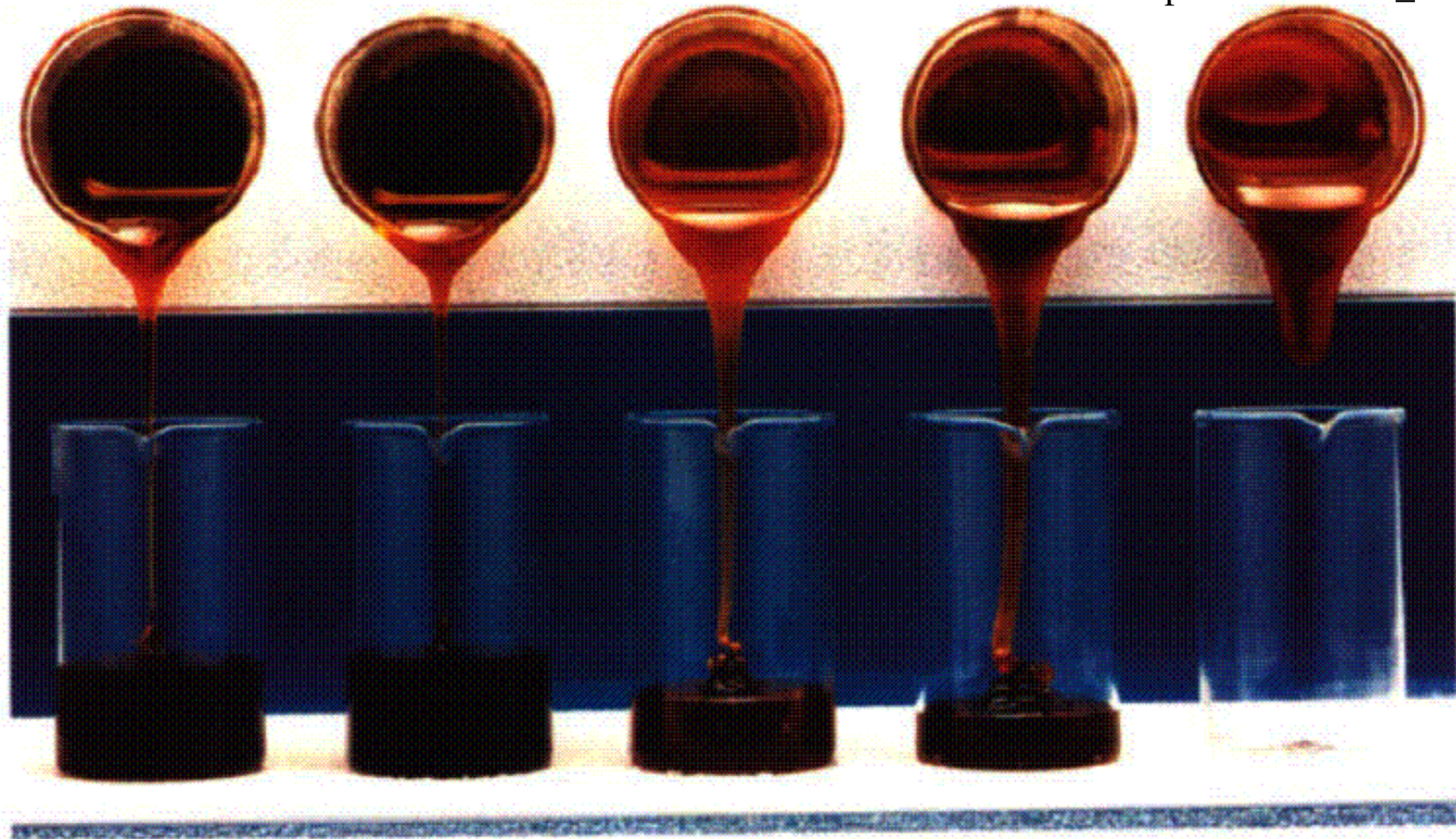
Viscosities can be related horizontally only. For example, the following oils have similar viscosities: ISO 460, AGMA 7 and SAE OIL 140.

The viscosity/temperature relationships are based on 95 VI oils and are usable only for mono grade engine oils, gear oils and other 95 VI oils.

Crankcase oils and gear oils are based on 100°C viscosity. The "W" grades are classified on low temperature properties. ISO oils and AGMA grades are based on 40°C viscosity.

Oil viscosity at room T

www.widman.biz/uploads/Corvair_oil.pdf

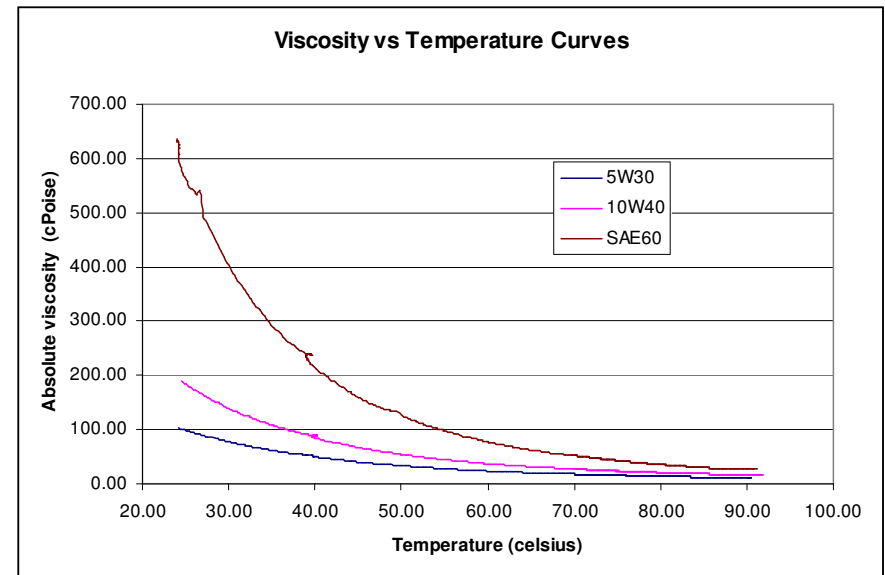
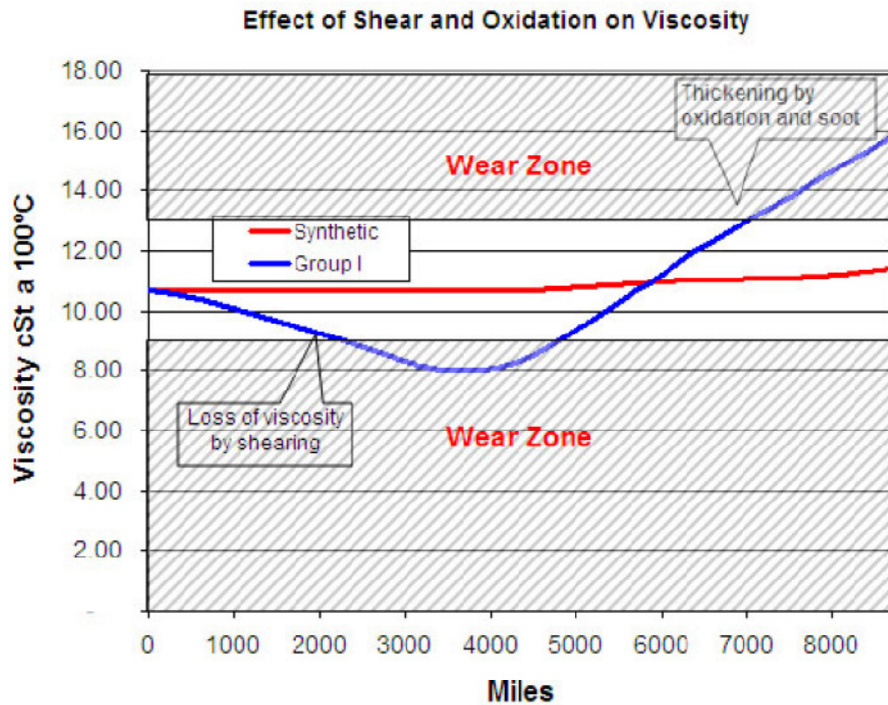


0W-40 0W-30 5W-30 10W-30 15W-40

Low —————> High

Viscosity

Degradation of oil

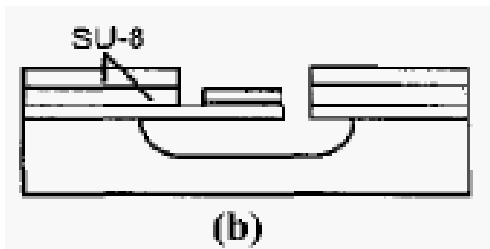


Oil will deteriorate from 10.3 cSt to 13.3 cSt at 100 C (operating T)
Corresponds to a change from 65.2 cSt to 110 cSt at 40 C – Wang, 2001

Approximately a 50 cSt resolution is needed at 40 C.

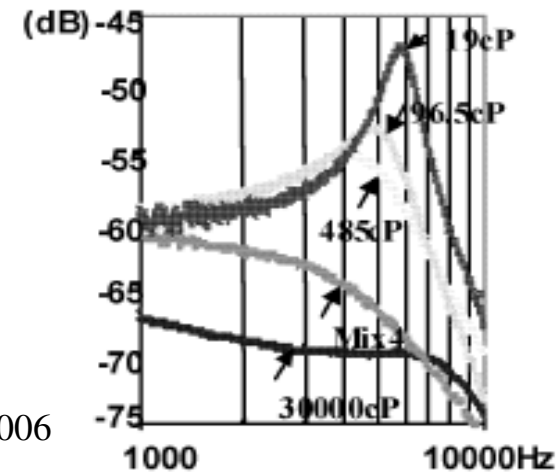
Cantilever MEMS Viscometers

- Cantilever Beam resonators
 - Change in natural frequency is correlated to viscosity
 - Electromagnetic or PZT actuation - Complex to integrate and fabricated
 - Optical readout
 - Reliability in harsh environments?
 - CMOS compatibility?



Zhao et al, 2005

Ramkumar at al, 2006



Naser et al, 2006

Fig. 3b: Experimental amplitude and phase of deflection for a silicon cantilever ($70\mu\text{m} \times 200\mu\text{m} \times 3000\mu\text{m}$) oscillating in various viscous fluids.

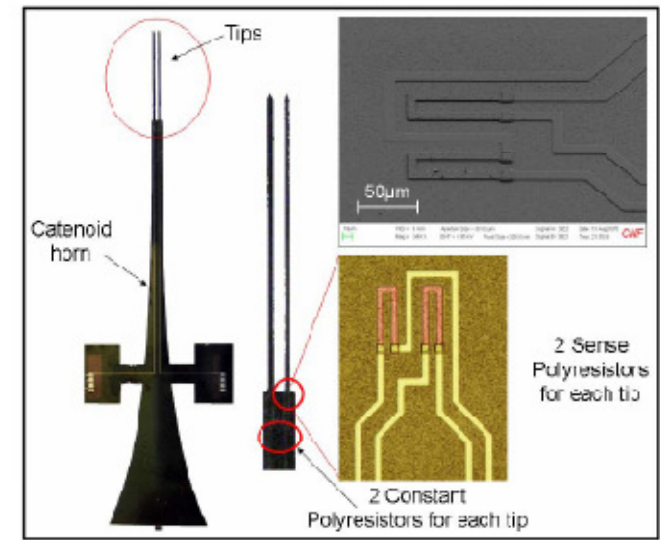
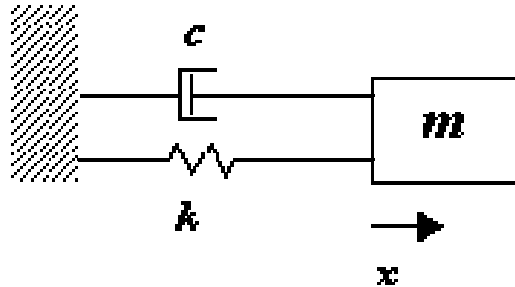
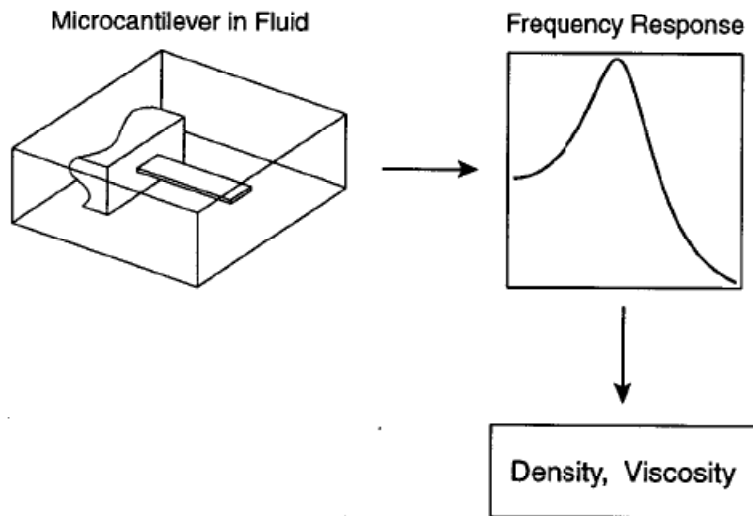


Fig. 2. Optical photograph of the fabricated device and SEM of polysilicon resistors.

Cantilever MEMS Viscometers



$$m \frac{\partial^2 x}{\partial t^2} + c \frac{\partial x}{\partial t} + kx = 0$$



$$A(\omega) = \frac{A_0 \omega_R^2}{\sqrt{(\omega^2 - \omega_R^2)^2 + \frac{\omega^2 \omega_R^2}{Q^2}}}$$

$$\omega_R = \frac{\omega_{vac}}{\sqrt{1 + \frac{\pi \rho b^2}{4\mu} \Gamma_r(\omega_R)}} \quad Q = \frac{4\mu}{\pi \rho b^2 \Gamma_i(\omega_R)} + \Gamma_r(\omega_R)$$

ω_{vac} – resonance in vacuum

ω_R – resonance in fluid

μ – mass per unit length of cantilever

ρ – density

b – beam width

Γ – hydrodynamic function (Navier-Stokes, density, viscosity and geometry)

S. Boskovic, J. Chon, P. Mulvaney, and J.E. Sader,
"Rheological measurements using microcantilevers," *Journal of Rheology*, vol. 46pp, 2002, pp. 891-899.

MEMS Viscometer

Design considerations

- CMOS compatible
- Precise amplitude control
- Simple read out (non-optical)
- Easy to fabricate
- Robust and reliable
- Actuation at resonant frequency is not needed
 - Measure power required to maintain a constant precise amplitude
- Thermal actuation?

Thermally Actuated Beams

- Large displacement
- Slower movement
- Lots of power
- Applications
 - Switches
 - Latching
 - Optical
 - Micro-robots
 - Micro-grippers

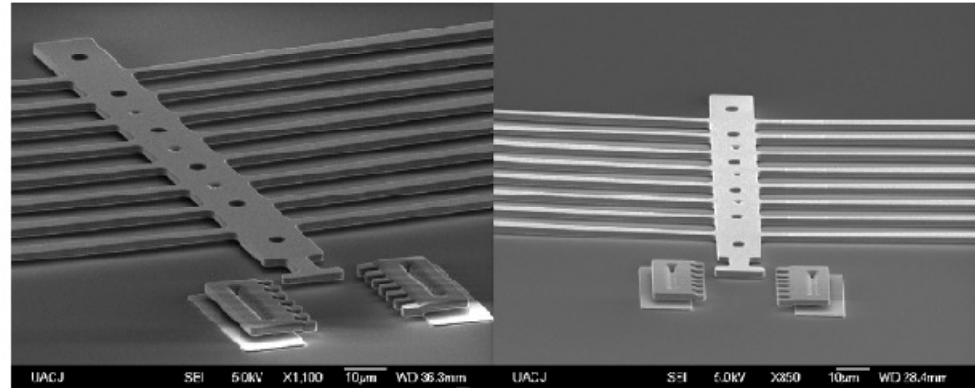


Fig. 6. SEM images of two of the fabricated actuators.

Jorge Varona et al. *Design of MEMS vertical-horizontal chevron thermal actuators*, Sensors and Actuators A: Physical, Volume 153, Issue 1, 25 June 2009, Pages 127-130,

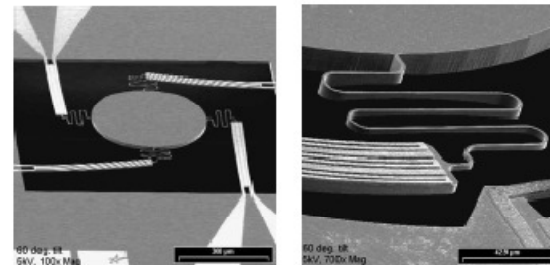
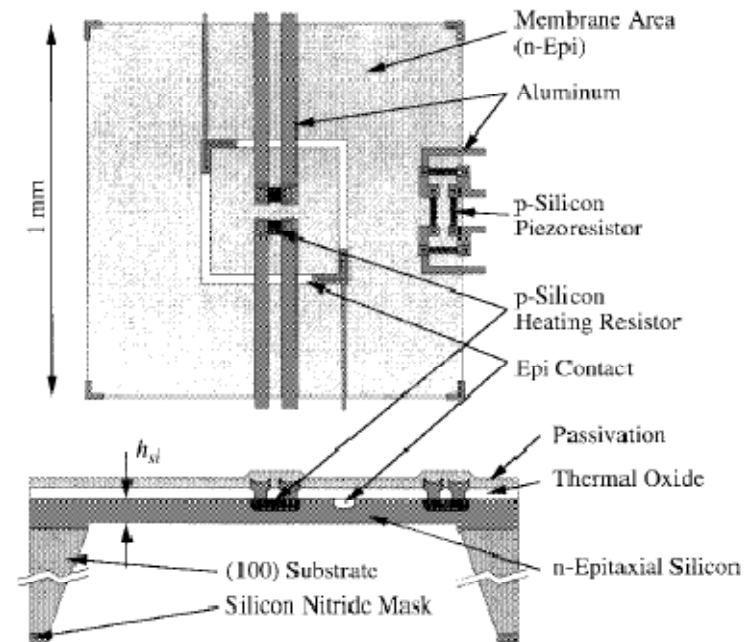


Figure 1. A SEM micrograph of a thermally actuated 3D micromirror developed at the Institute of Microelectronics (IME).

J Singh, J H S Teo, Y Xu, C S Premachandran, N Chen, R Kotlanka, M Olivo and C J R Sheppard, *A two axes scanning SOI MEMS micromirror for endoscopic bioimaging* Journal of Micromechanics and Microengineering, February 2008, V18, p. 025001

Thermally Actuated Plates

- Large displacement
- More power
- Applications
 - Valves
 - Optical
 - Ultrasound



Oliver Brand, Mark Hornung, Henry Baltes, Member, IEEE, and Claude Hafner, *Ultrasound Barrier Microsystem for Object Detection Based on Micromachined Transducer Elements*, JOURNAL OF MICROELECTROMECHANICAL SYSTEMS, VOL. 6, NO. 2, JUNE 1997 151

Microvisk Viscosity Sensor

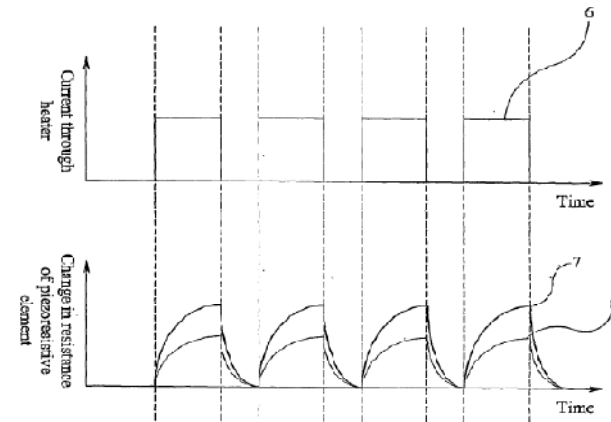
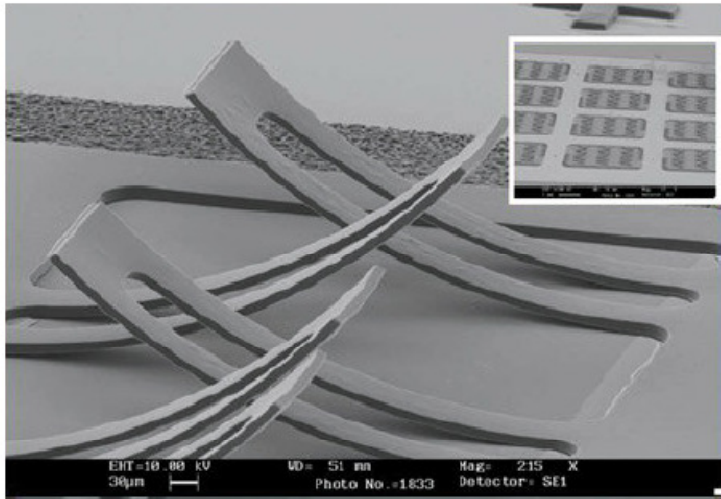
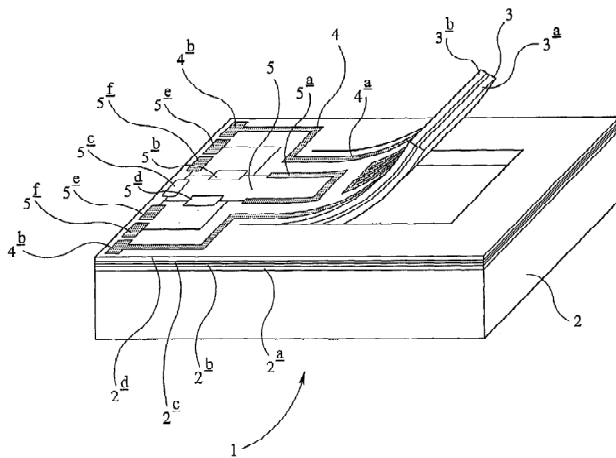
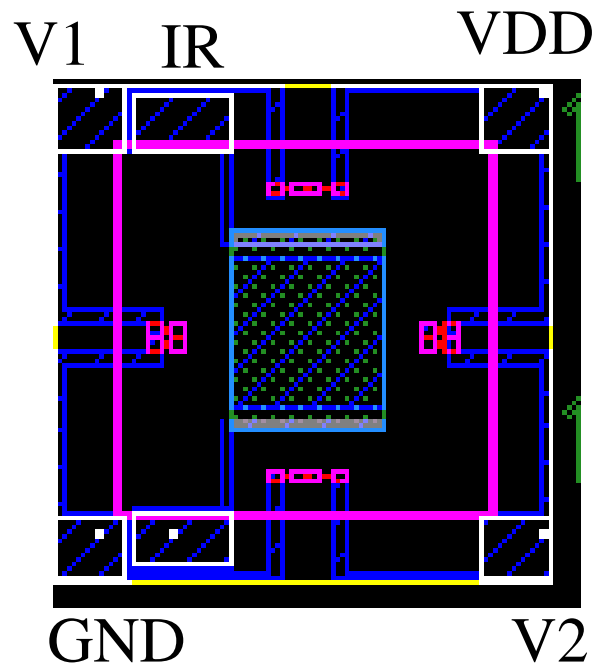


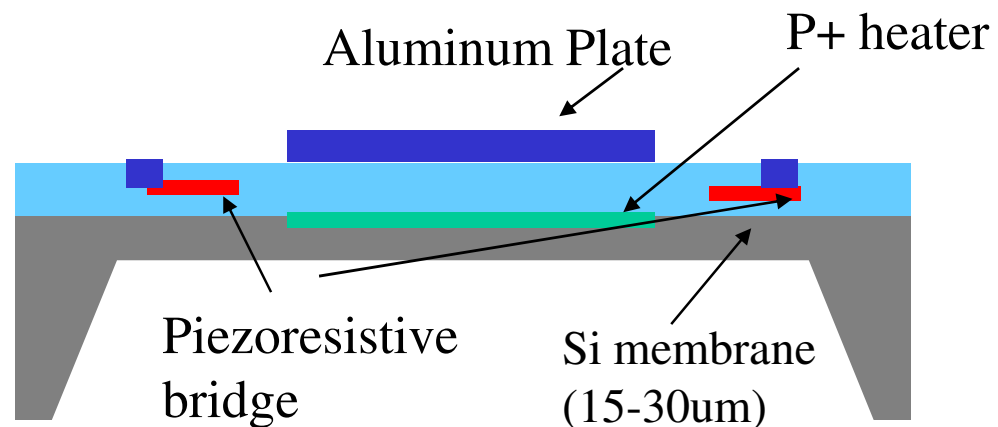
Figure 2: Time-varying signals obtained from fluids of different viscosity.



Proposed: Electrothermal MEMS Viscometer



- In-situ P+ Si heater (joule heating).
- In-situ poly-silicon piezoresistor bridge to monitor membrane deflection
 $V_{out} = V2 - V1$
- Vertical displacement due to thermal coefficient of expansion difference between Si/SiO₂ and Al (bimetallic effect)
- Resistance to motion is related to the viscosity of the fluid.



Oil viscosity testing

$V_{\text{supply}}=14\text{V}$

$O_{\text{sc}}=9\text{V}, 5\text{Hz}$

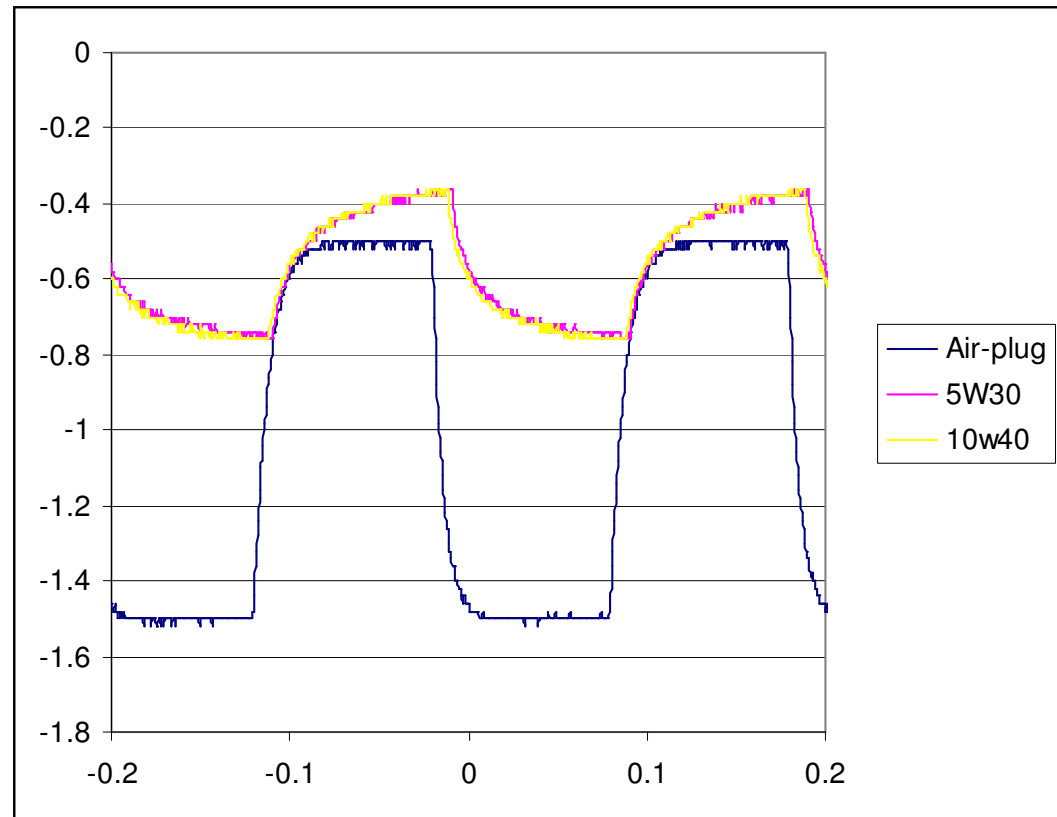
$G=41$

Measurements taken at
room temperature 22C

5W30 – 115.4 cSt

10W40 – 239.4 cSt

SAE60 – 758.4 cSt



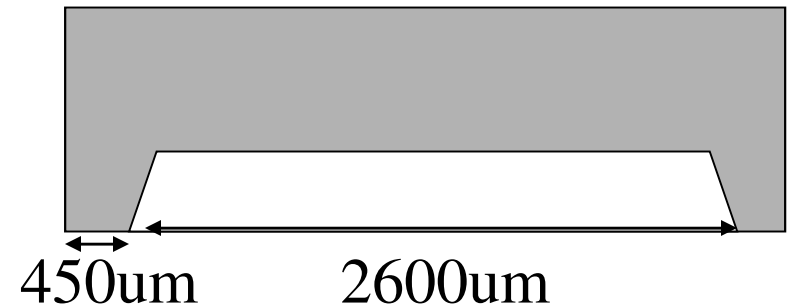
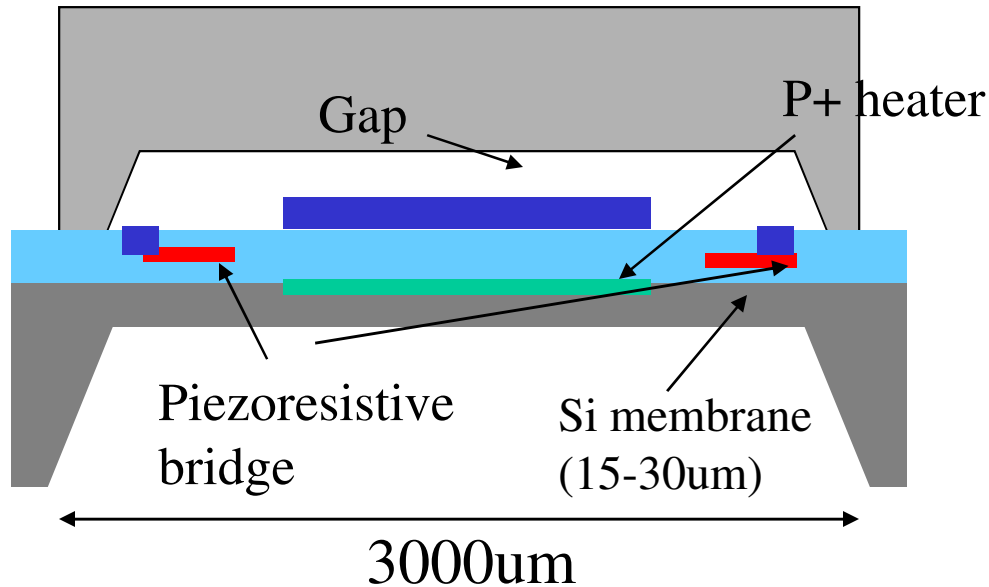
$\Delta V(5W30)=407\text{mV}$

$\Delta V(10W40)=388\text{mV}$

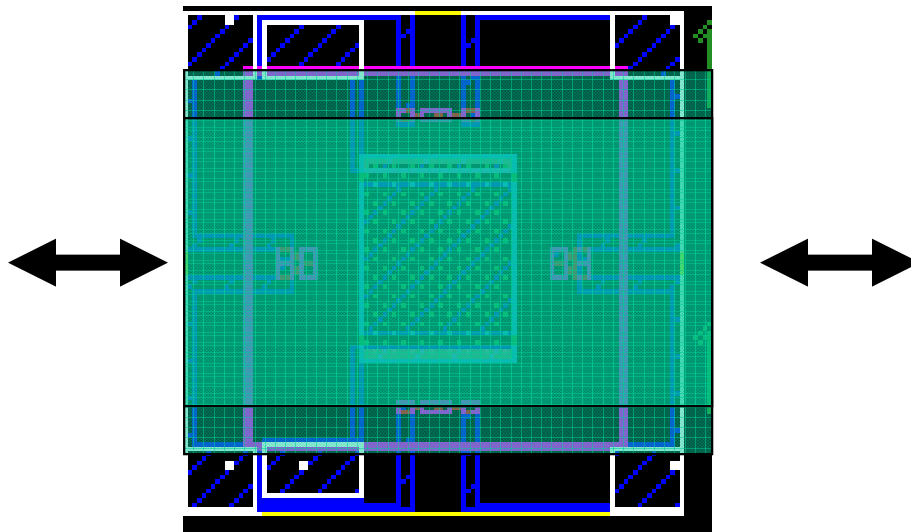
19mV difference – not consistent

Need to amplify resistance of fluid motion to improve resolution

Cover for Viscometer



- Cover amplifies resistance to movement of membrane.
- Cover is smaller to allow for wirebonds.
- Gap can be easily adjusted with KOH etch time.



Oil viscosity testing – with cover

$V_{\text{supply}}=14\text{V}$

Osc=9V, 5Hz

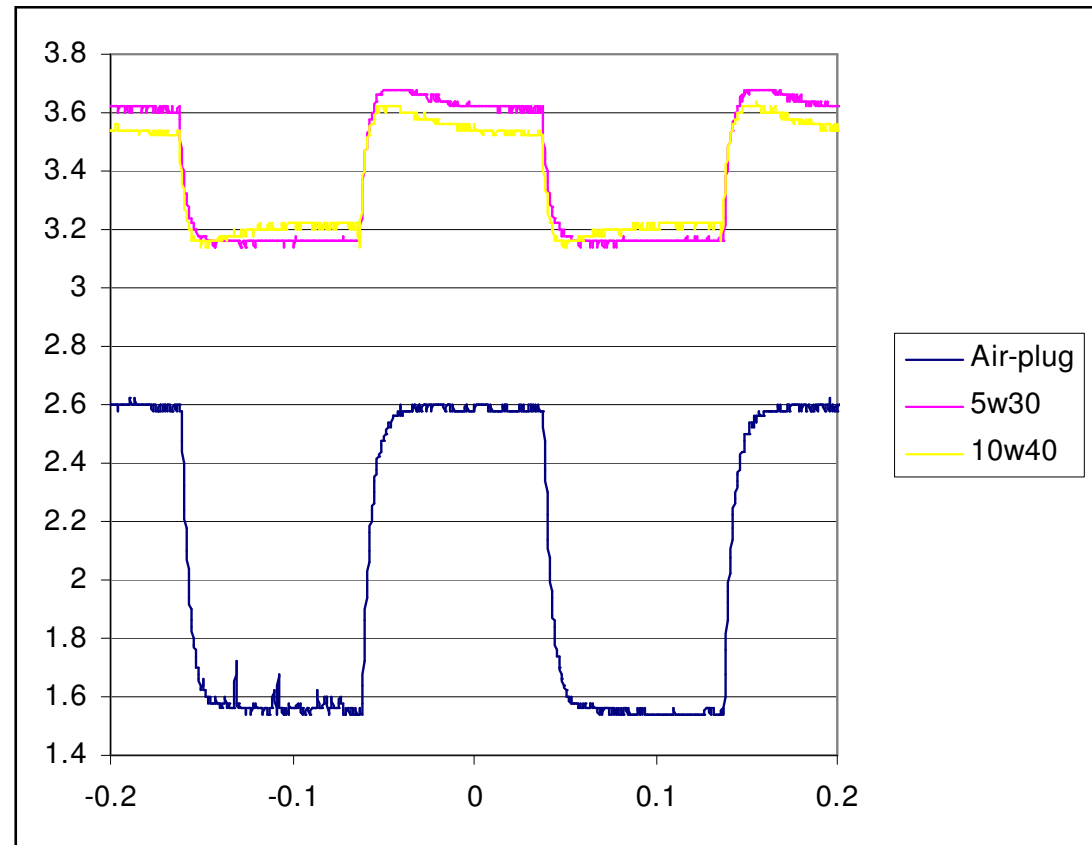
$G=41$

Measurements taken at
room temperature 25C

5W30 – 124.3 cSt

10W40 – 146.5 cSt

20 cSt resolution



$\Delta V(5W30)=545\text{mV}$

$\Delta V(10W40)=471\text{mV}$

74mV difference

Improved resolution.

Conclusions

- Cooling effect of oil
- Local heating
 - Quick measurements avoid heating the oil.
- Front plate to increase sensitivity
 - Need to determine best gap distance.
- Frequency of interrogation
 - Need to determine optimal frequency to avoid the membrane heating up to steady state.

- Need to interrogate without affecting liquid under test.

Microvisk Update - 2009

•Pulse heat

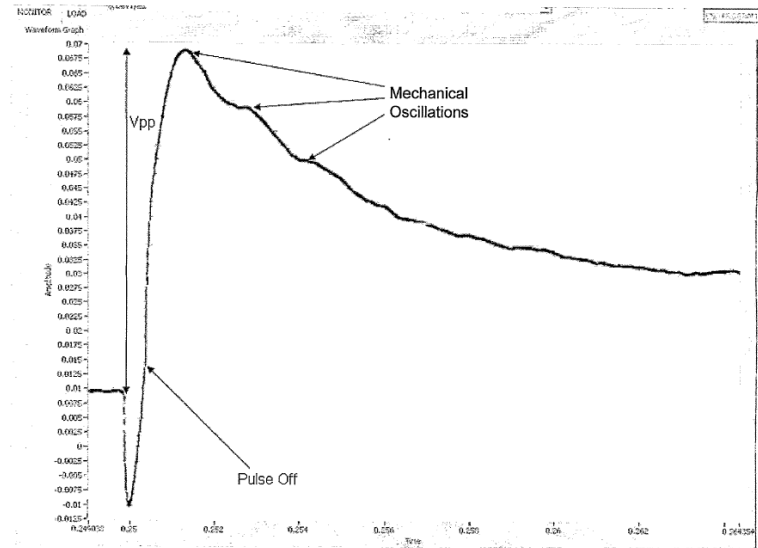
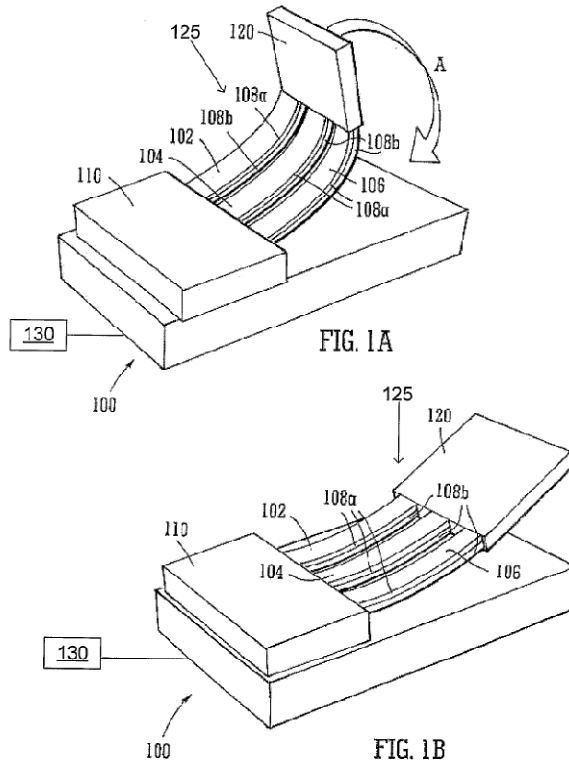
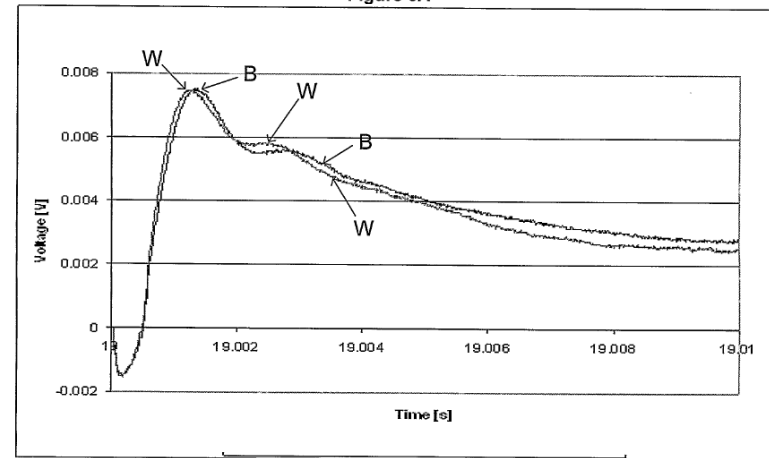


Figure 5A



V. Djakov, "Fluid Probe," 2009,
p. 45. WO2009022121A2
Microvisk Limited

Thermal resonator

- 1997 paper by Brand
- Thermal resonator vibrates with heat burst
- Used to monitor polymer formation in PDMS solutions

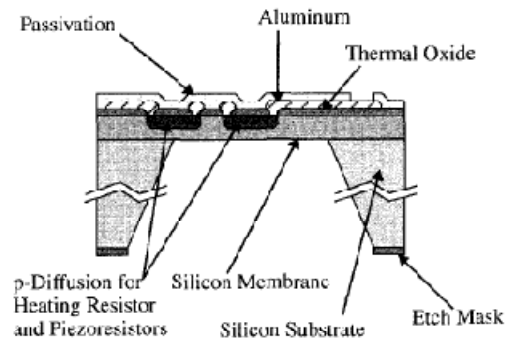


Fig. 1: Schematic of the membrane resonator with heating resistor for excitation and piezoresistors for detection.

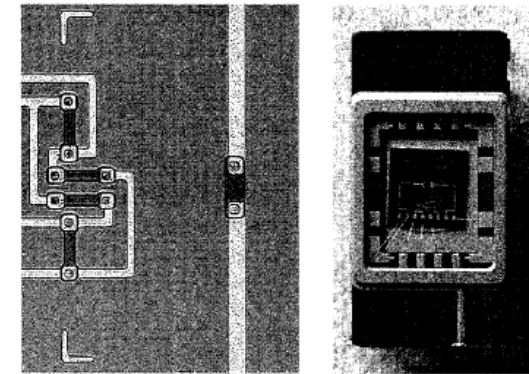


Fig. 2: (Left) Photograph of a fabricated 1.5 mm by 1.5 mm membrane resonator with the driving resistor in the center and the piezoresistors arranged in a Wheatstone bridge close to the edge. (Right) Complete membrane structure after wire bonding but prior to sealing

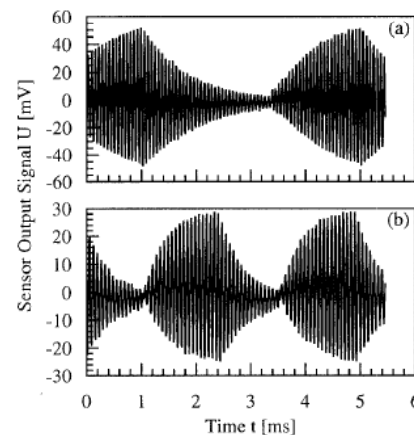


Fig. 4: Output signal of the membrane resonator subject to a burst excitation for (a) a 1 cSt ($8.2 \cdot 10^{-4}$ Pa·s) and (b) a 10 cSt ($9.4 \cdot 10^{-3}$ Pa·s) PDMS solution. Note that trace (a) was measured at a lower burst rate because of the longer decay time in the less viscous solution.

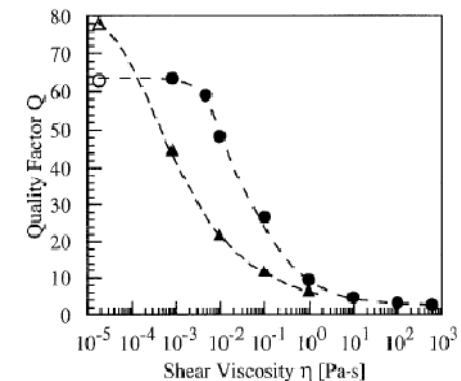
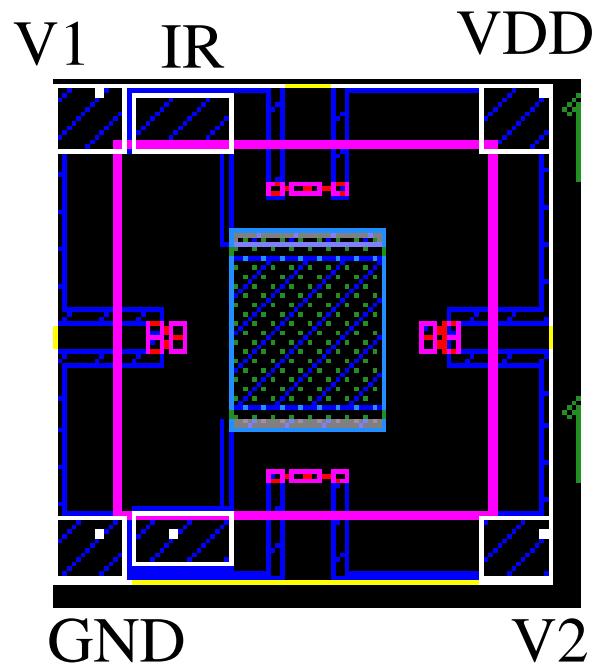


Fig. 5: Quality factor of the piezoelectric transducer (circles) and a 1.4 mm by 1.4 mm membrane resonator (triangles) as a function of the shear viscosity in air (open symbols) and different PDMS solutions (solid symbols).

O. Brand, J.M. English, S.A. Bidstrup, and M.G. Allen, "Micromachined viscosity sensor for real-time polymerization monitoring," Proceedings of the 1997 International Conference on Solid-State Sensors and Actuators, vol. 1, 1997, pp. 121-124.

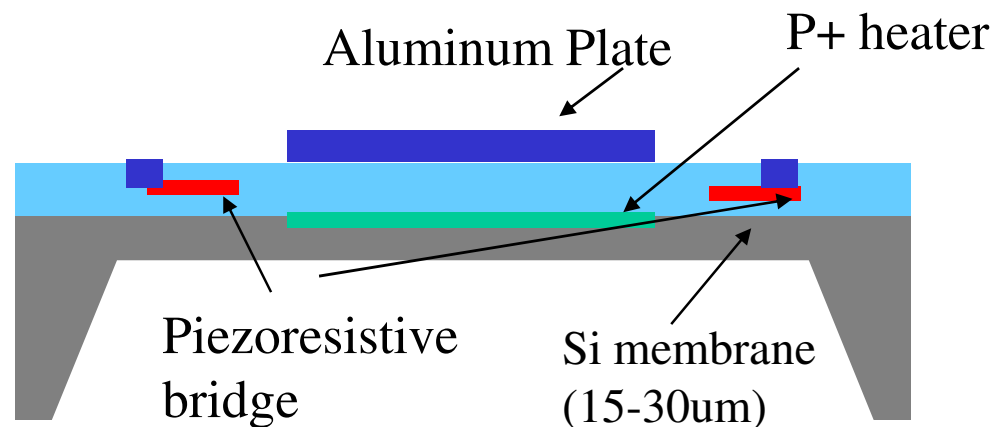
Proposed: Electrothermal MEMS Viscometer



- In-situ P+ Si heater (joule heating).
- In-situ poly-silicon piezoresistor bridge to monitor membrane deflection

$$V_{out} = V_2 - V_1$$

- Short thermal pulse to set diaphragm in motion.
- Damped simple harmonic oscillator with initial displacement determined by thermal pulse.
- Initial vertical displacement due to thermal coefficient of expansion.
- Viscosity of the fluid dampens vibration
 - Q changes, also natural frequency.

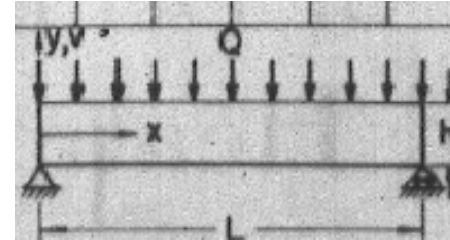


US Patent Pending

Operation Principle

- Plate behavior to suddenly applied heat
 - Theory developed in the 1950's for jet propulsion.
 - Static and dynamic (vibration) components
 - Dynamic vibration is at natural frequency of the plate
 - Goal was to minimize vibrations

$$\frac{Eh^3}{12(1-\nu^2)} \frac{\partial^4 w(x, y, t)}{\partial x^4} + \rho h \frac{\partial^2 w(x, y, t)}{\partial t^2} = -\frac{1}{1-\nu} \nabla^2 M_T$$



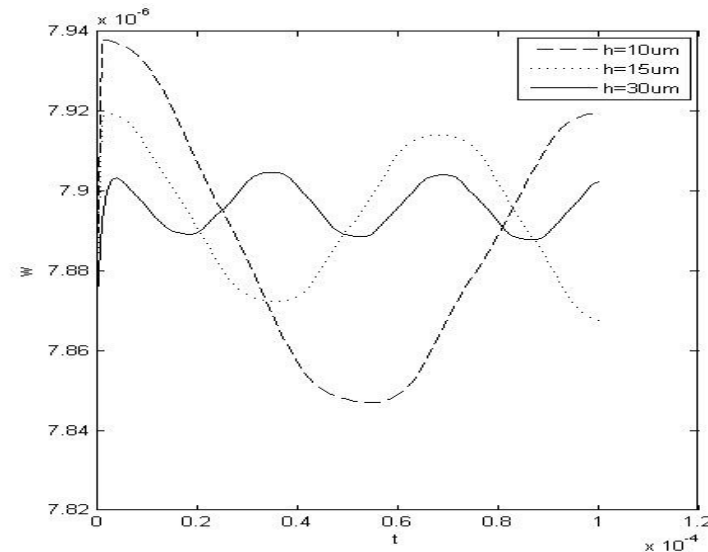
B. Boley and J. Weiner, Theory of Thermal Stresses, Malabar, Florida: Robert E. Kreiger Publishing Company, 1985.

- Natural frequency of a square plate due to a heat pulse

- Due to the inertia term
- Depends on both thickness and size of the diaphragm
- Amplitude depends on temperature
- Natural frequency does not depend on temperature

$$\omega_n = \frac{B^2 \pi^2 (m^2 + \frac{a^2}{b^2} n^2) \tau}{t} = \frac{\left(\frac{h}{a\sqrt{\kappa}} \left(\frac{D}{h\rho} \right)^{1/4} \right)^2 2\pi^2 \frac{\kappa}{h^2}}{t} = \frac{2\pi^2}{a^2} \sqrt{\frac{D}{h\rho}}$$

$$w(x, y, t) = w_{st} - w_{dyn}$$



Operation Principle

Plate-fluid interaction

- Plate vibration in fluid
 - Fluid-structure interaction theory
 - Frequency shift due to density of fluid – Virtual Added Mass
 - Viscous effects are neglected.
 - Only become important for large viscosity values

$$\omega_{fluid} = \frac{\omega_{vacuum}}{\sqrt{1 + \beta}}$$

$$\beta = 0.669 \frac{\rho_{fluid} a}{\rho_{plate} h}$$

- 2009 paper relates shifts in frequency to viscosity for microstructures

$$\beta = 0.6538 \frac{\rho_{fluid} a}{\rho_{plate} h} (1 + 1.082 \xi)$$

$$Q = 2\pi \frac{\text{energy_stored}}{\text{energy_dissipated_per_cycle}} \approx \frac{0.95}{\xi^2}$$

$$\xi = \sqrt{\frac{\nu}{\omega a^2}}$$

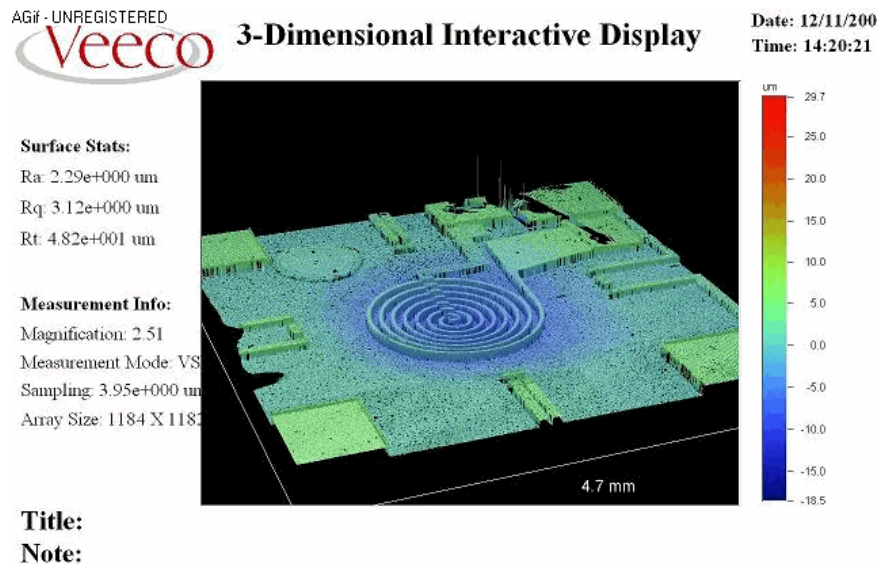
ν - kinematic viscosity

ρ - density

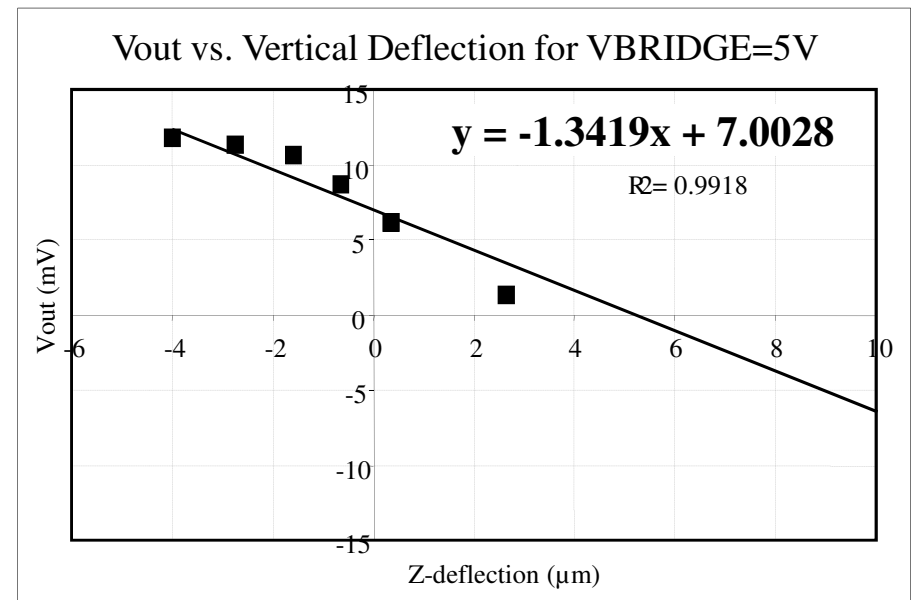
Y. Kozlovsky, "Vibration of plates in contact with viscous fluid: Extension of Lamb's model," Journal of Sound and Vibration, vol. 326, 2009, pp. 332-339.

Vertical Displacement Calibration

- Veeco Wyko White Light Interferometer
- Measure z-displacement and $V_{out}=V_2-V_1$



- Images at 0, 50, 100, 150, 200 and 250m A



- Calibration of Vout to vertical deflection.

Thermal MEMS Viscometer Design Outline

- Based on operation principles
 - Determine Diaphragm Thickness
 - Thin enough for significant displacement
 - Thick enough to prevent buckling
 - Evaluate diaphragm thickness vs. vertical displacement
 - Determine Pulse Energy
 - Need enough energy to obtain significant diaphragm deflection
 - Short enough to prevent interaction with fluid
 - Temperature affects initial displacement amplitude
 - Monitor diaphragm temperature with varying pulse times
 - Dynamic Measurements
 - Natural frequency and quality factor Q in air
 - Natural frequency and quality factor Q in fluid
 - Viscosity measurement

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Determining Diaphragm Thickness v. Linear actuation

• $h < 10\mu\text{m}$

Rapid increase with lower power, hysteresis effect – snapback

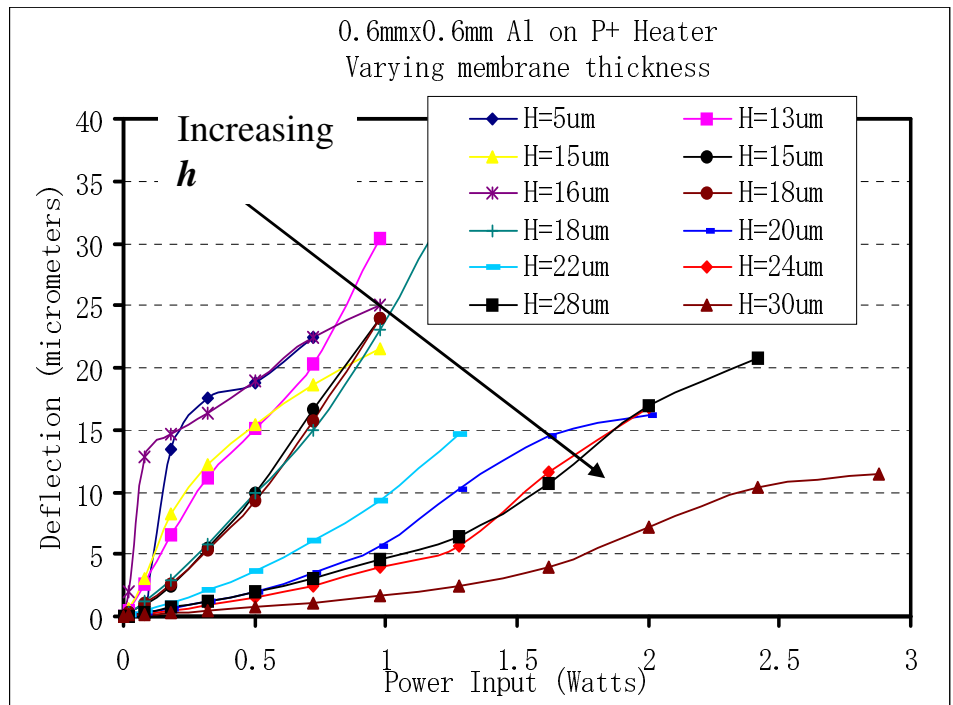
• $10\mu\text{m} > h > 20\mu\text{m}$

Linear relation to power

• $h > 20\mu\text{m}$

Rapid increase at 1W
leveling off at 2W
Buckling

• Good match to theoretical predictions



$$a = 2.5\text{mm}$$

• Keep h between 15 and $20\ \mu\text{m}$

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Determining Pulse Energy - Theoretical

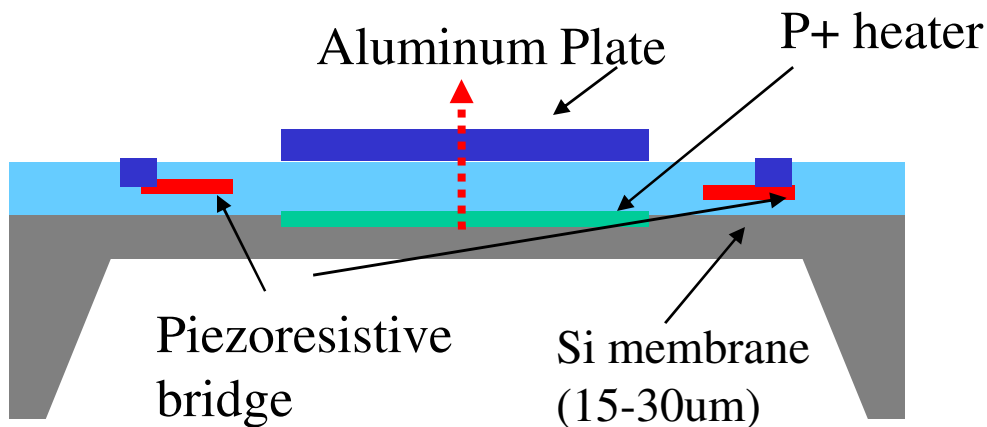
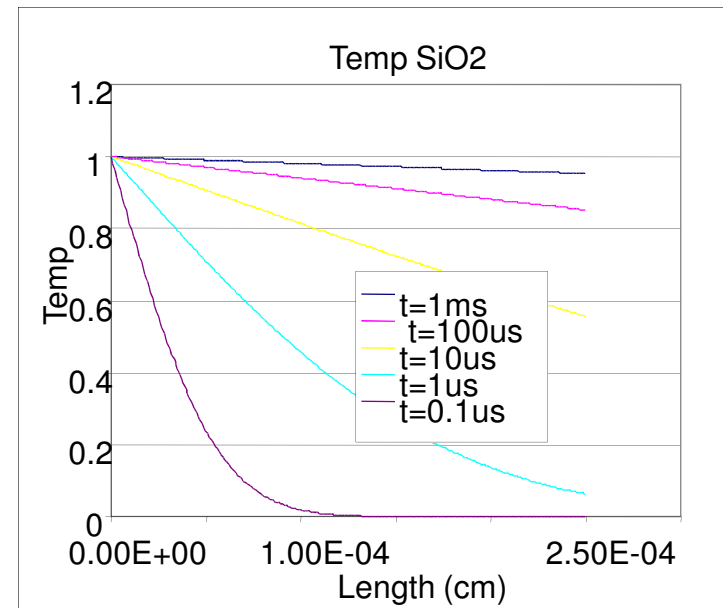
1-D Transient Temperature Equation

$$K_{\text{SiO}_2} = 0.009 \text{ cm}^2/\text{s SiO}_2$$

semi-infinitely long body $x \geq 0$

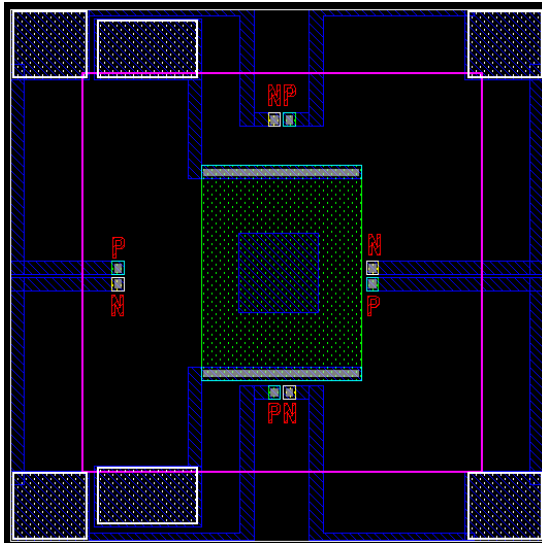
$$\frac{\partial T}{\partial t} = \kappa \frac{\partial^2 T}{\partial x^2}$$

$$T = T_a \operatorname{erfc}\left(\frac{x}{2\sqrt{\kappa t}}\right)$$

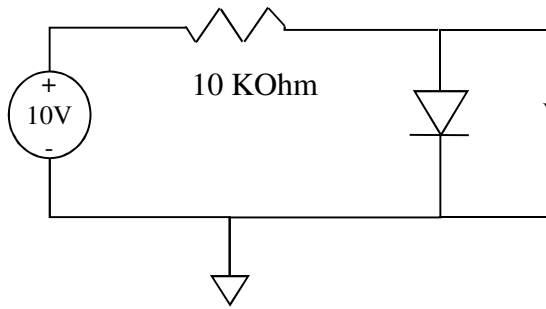
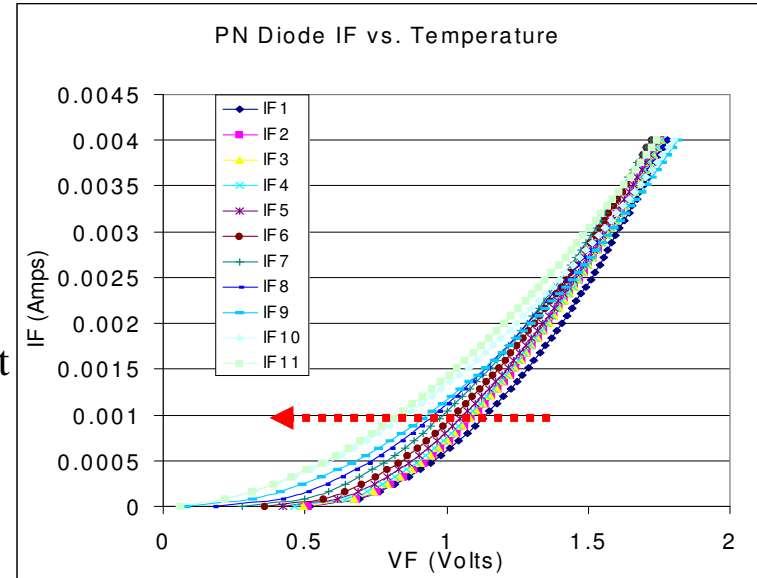


$t \sim 1\mu\text{sec}$ to reach
SiO₂/fluid interface

Diaphragm Temperature Evaluation

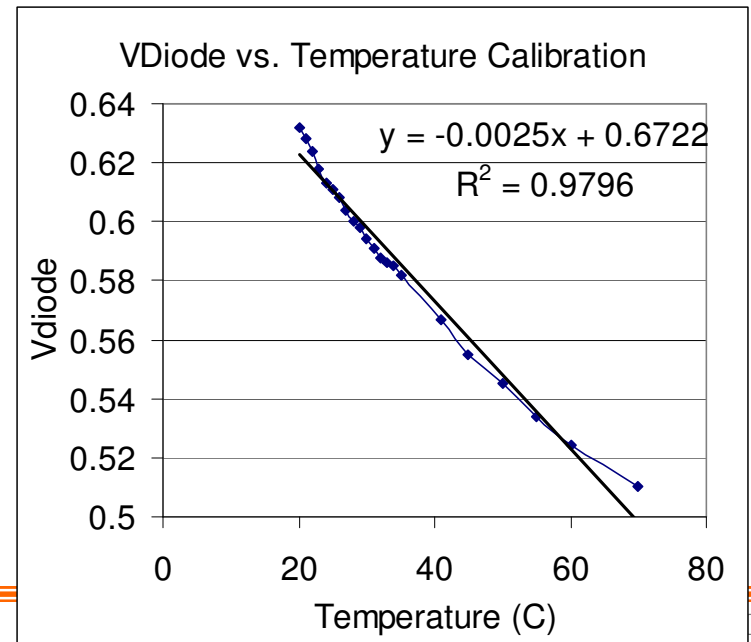


For constant current
 $\Delta V = -2.2 \text{ mV/}^\circ\text{C}$

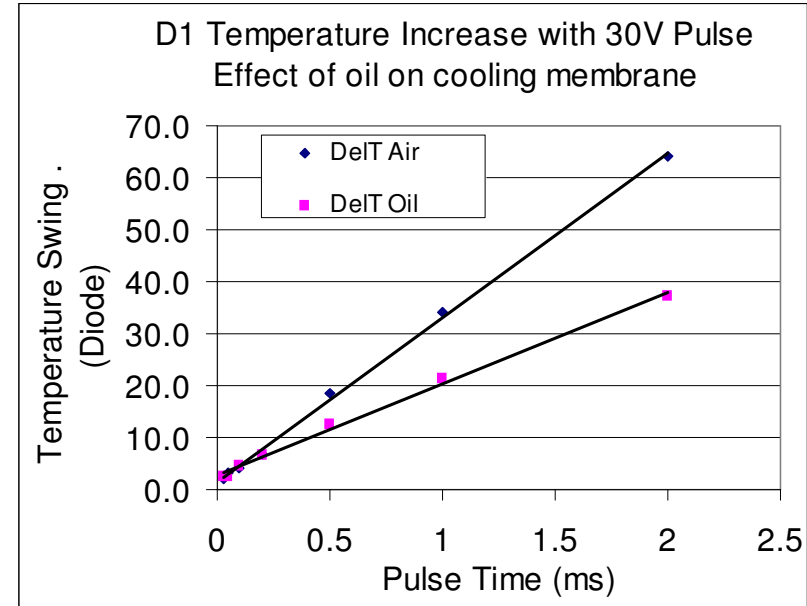
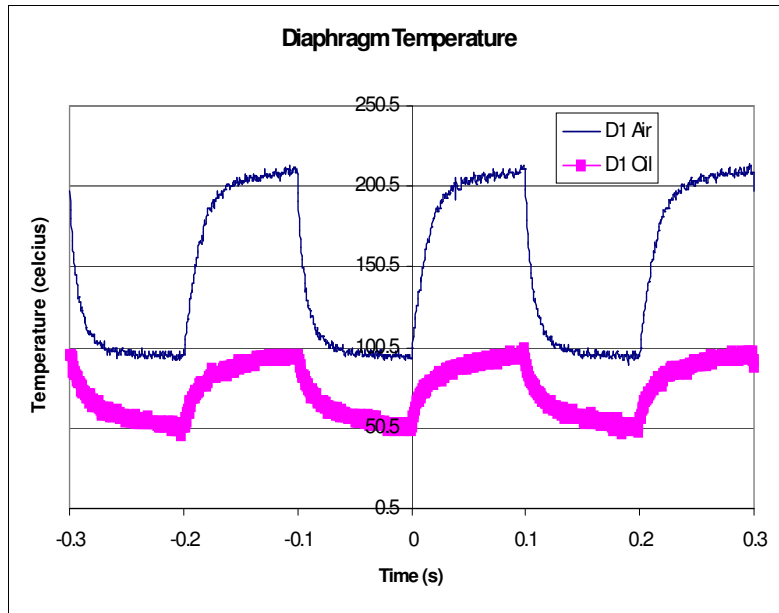


$\Delta V = -2.5 \text{ mV/}^\circ\text{C}$

Calibrated in oven with a constant current circuit



Pulsed Diaphragm Temperature Evaluation in Fluid



- Forward biased diode to monitor temperature at 5 Hz, 200 ms pulse.
- 100 C swing in air
- 50 C swing in oil

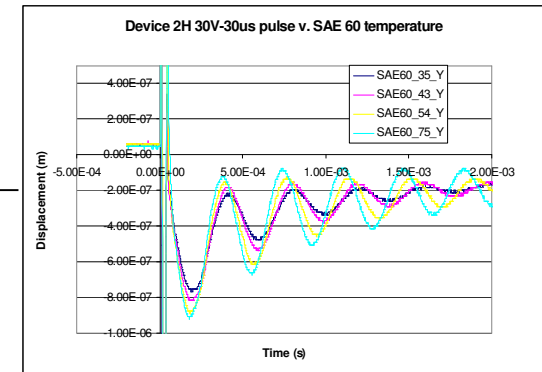
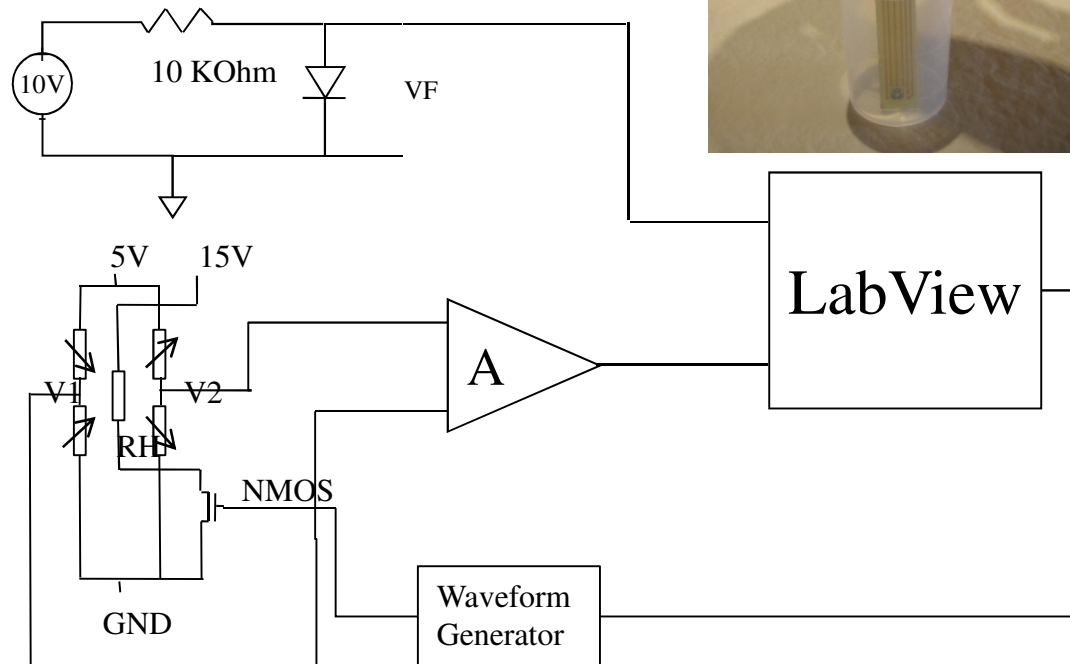
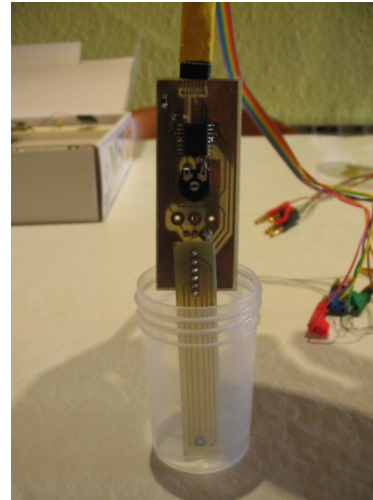
- 30 V pulse.
- No temperature differences can be appreciated $t_{\text{pulse}} < 100 \text{ us}$
- Energy has to be large enough to set diaphragm vibrating at its natural frequency without damaging the device.

Thermal MEMS Viscometer Design Outline

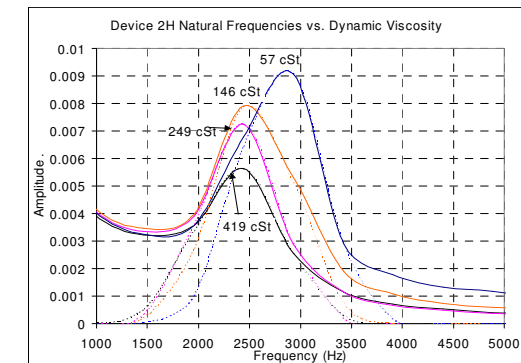
- Based on operation principles
 - Determine Diaphragm Thickness
 - Thin enough for significant displacement
 - Thick enough to prevent buckling
 - Evaluate diaphragm thickness vs. vertical displacement
 - Determine Pulse Energy
 - Need enough energy to obtain significant diaphragm deflection
 - Short enough to prevent interaction with fluid
 - Temperature affects initial displacement amplitude
 - Monitor diaphragm temperature with varying pulse times
 - Dynamic Measurements
 - Natural frequency and quality factor Q in air
 - Natural frequency and quality factor Q in fluid
 - Viscosity measurement

LabView Integration

- PCB electronics
- LabView analysis for real time monitoring
- Long term analysis



FFT



Calibration

Outputs:
Temperature
F
Q
Viscosity

Natural Frequency in Air

- 30V - 30us square pulse

- Theoretical natural vibration frequency SSSS

$$f_{ij} = \frac{\lambda_{ij}^2}{2\pi a^2} \left[\frac{Eh^3}{12\gamma(1-\nu^2)} \right]^{1/2}$$

$$f_{11} = 16579 \text{ Hz}$$

λ – function (boundary conditions, a/b , ν)

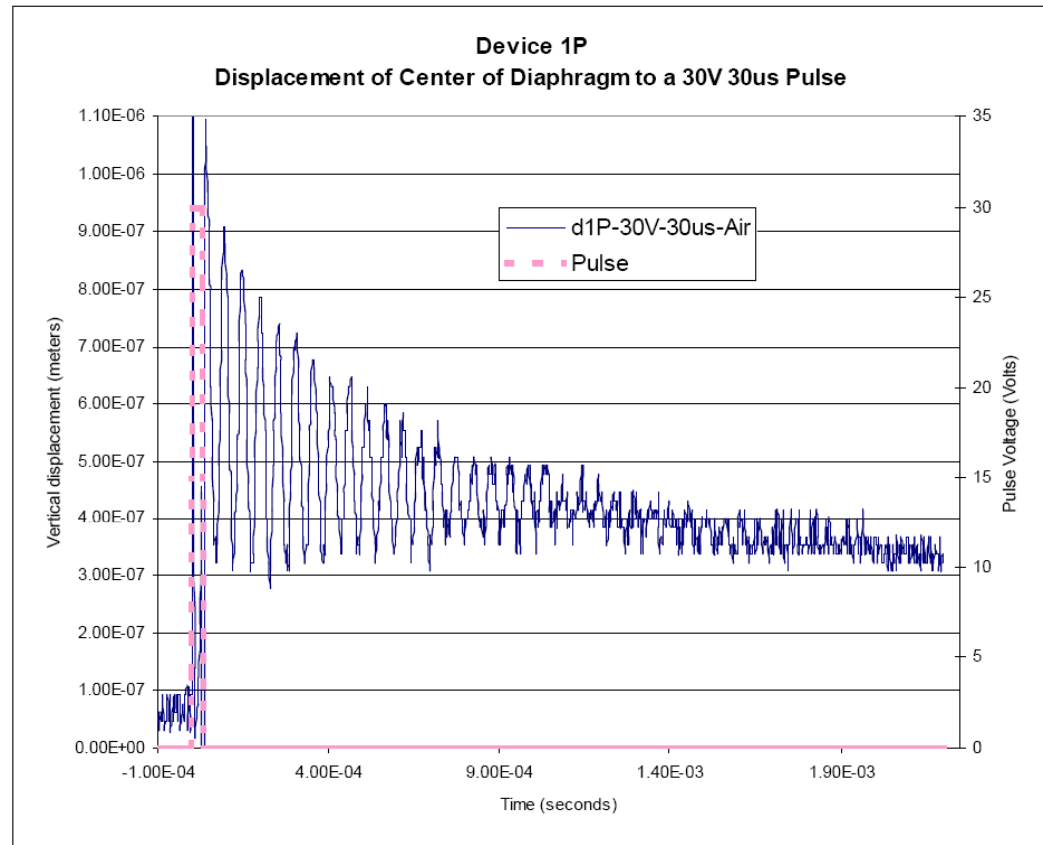
E – Young's modulus

h – plate thickness

γ – mass per unit area of plate

a – length of plate

ν – Poisson's ratio



$T=64 \text{ us}$, $f=15,625 \text{ Hz}$ – corresponds to natural frequency of plate

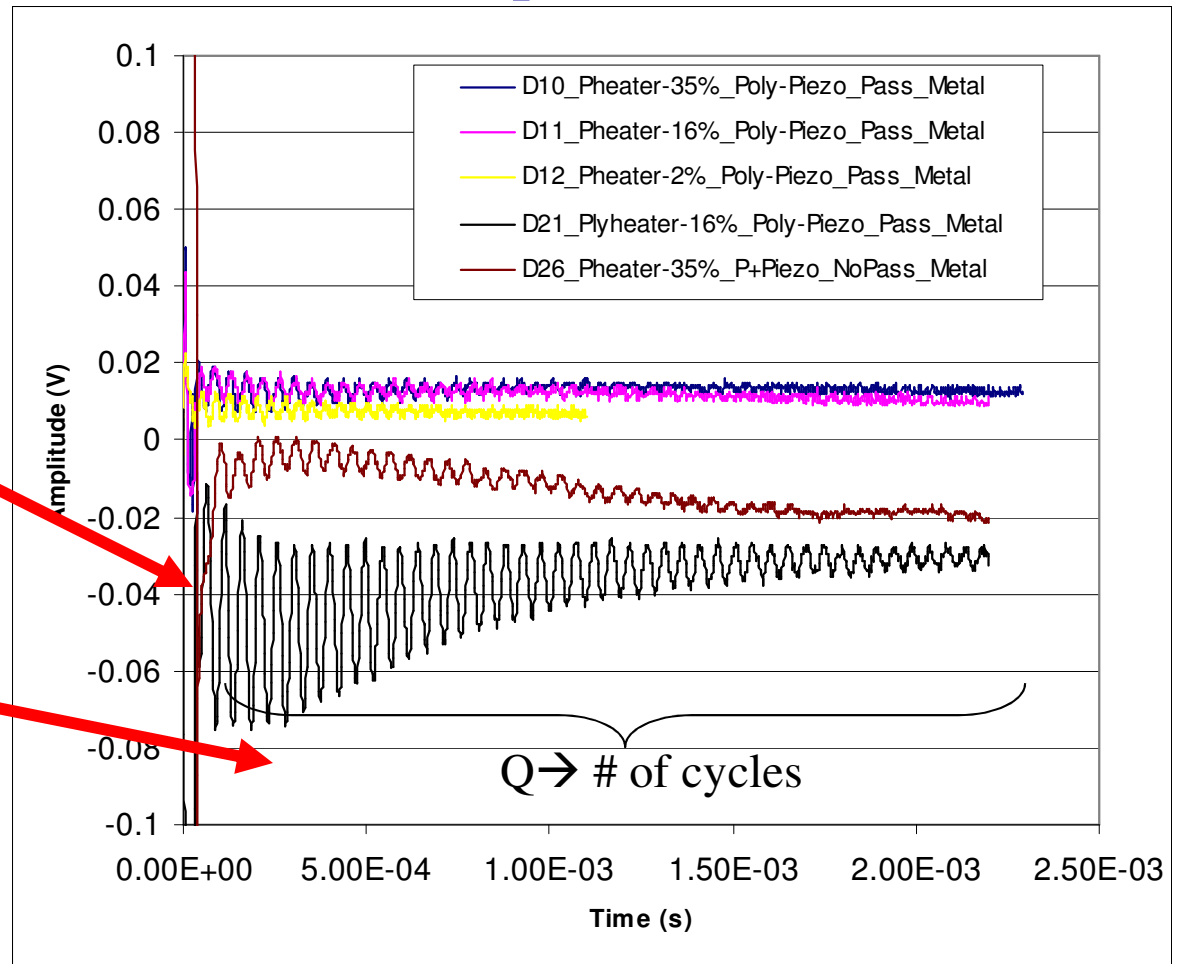
Experimental Responses

Frequency measured with FFT (labview).

Amplitude is measured as initial voltage peak to peak.

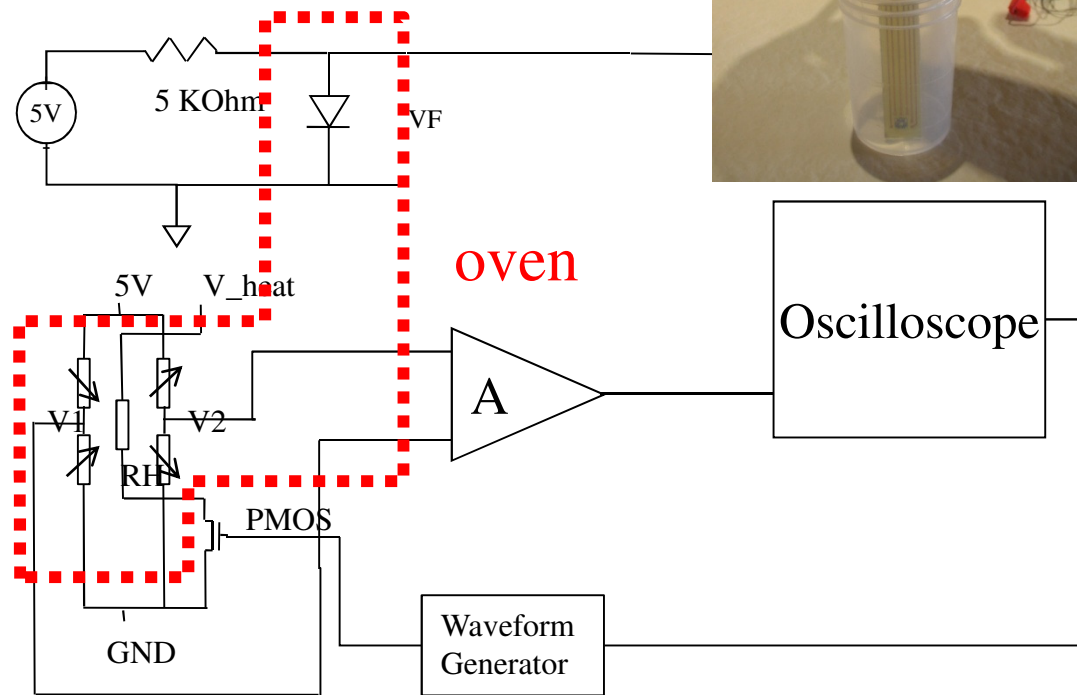
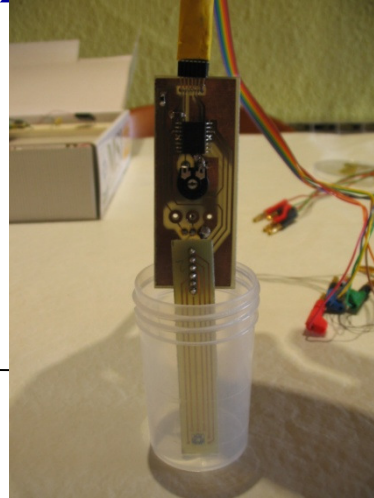
Q is measured by number of cycles.

Normalize results with respect to power in order to compare amplitude and Q.
(Rheat varies)

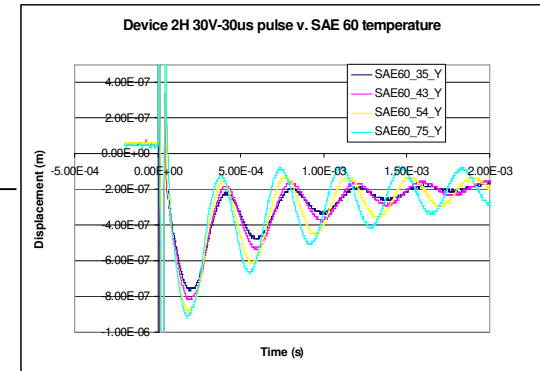


Test Setup for Screening Experiment

- PCB electronics
- LabView analysis for real time monitoring
- Long term analysis

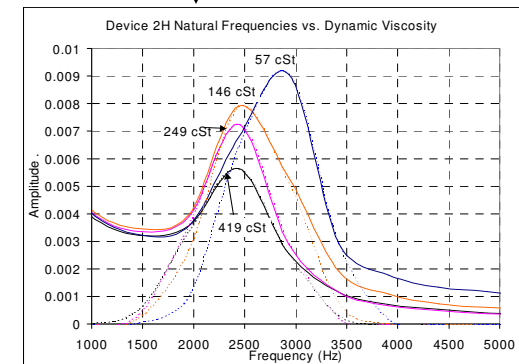


oven



LabView

FFT



Outputs:
Frequency
Amplitude
Q
Temperature

LabView Screenshot

TKTD5320 FFT of oscilloscope_Ivan.vi

File Edit View Project Operate Tools Window Help

VISA session: stop, %\GPIB0::5: %

dup VISA session: %

width 2: 3

cycles(Q2): 61

Fo2: 17845, Wvfrm Ampl: 2.36m

millisecond timer value: 9585000

error out: status: , code: d0, source: []

error in (no error): status: , code: d0, source: []

averaging type: Linear

DC value: 4.37m, RMS value: 6.15m

returned waveform: [Plot showing a decaying oscillation]

source (ch1:0): Channel 1

operation (entire wfm:0): Read entire waveform

starting point: 1, ending point: 500

advanced search: approx freq. (optional): 18.00k, search (+/- % of Fsampl.): 5.00

Vdiode: 0.60702, Temp_C: 24.399

FFT Amplitud 2 - Adjustable x-axis scale: [Plot showing a sharp peak at approximately 17800]

Threshold detection: width: 10, Ymax - Max Amplitude at Fo: 391.95n, df: 100.00, X location: 178.24

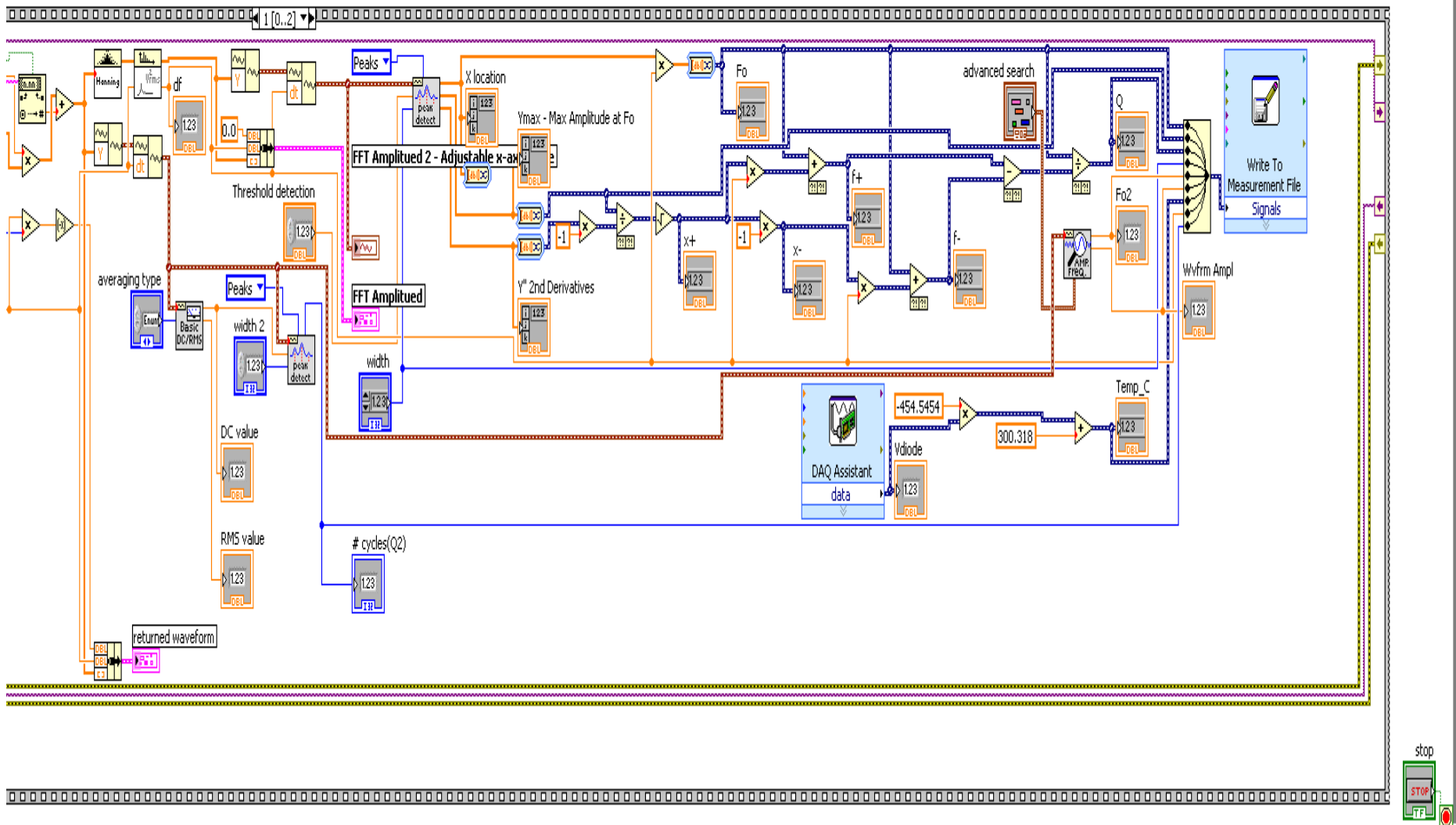
Y'' 2nd Derivatives: -39.60n

Fo: 17824, Q: 28.33

FFT Amplitud: [Plot showing a sharp peak at approximately 17800]

1. Connect to TK TDS340 oscilloscope by selecting the correct VISA session (GPIB0::5)
2. Adjust x and y scale in oscilloscope
3. Find resonant peak either by looking at the FFT Amplitude plot or searching around the known resonance.
4. Adjust FFT Amplitud 2 plot to see the resonant peak.
5. Adjust threshold to be able to detect peak. The width determines the number of data points to fit to a quadratic peak. It will also determine the Q. Needs to be >2. Keep constant through measurements, 3 is a good number.
6. Fo is calculated as Xlocation*df
7. $Q = fo / (f+ - f-)$ is calculated by finding x+ and x- at the 1/2 max amplitude in a quadratic fit of $Y = a * X^2 + b$ where $Y = 0.5 * Y'' * X^2 + Ymax$. Then $f+ = fo + df * x+$ and $f- = fo + df * x-$
8. Temperature is measured as the voltage drop on a forward-biased silicon diode, $Vsupply=5V$, $R=4.9\text{ kOhm}$.

LabView Code

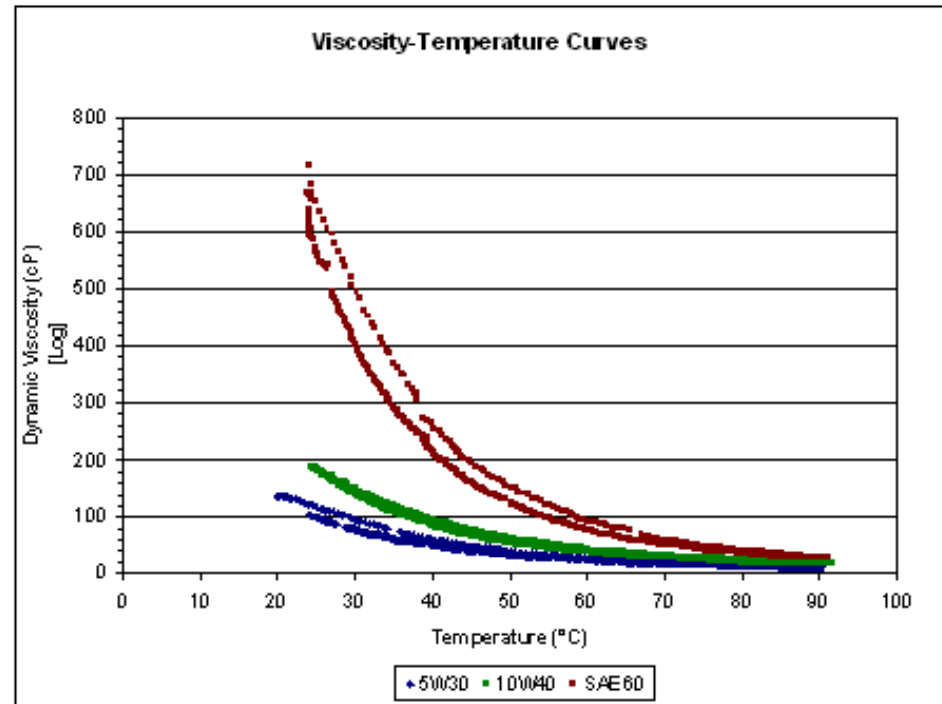


Sensor Viscosity Test

The viscosity of Motor oil has a strong dependence on temperature.

Change temperature of motor oil to test a range of viscosities.

Temperature also affects the natural frequency of vibration. But this effect is linear and can be easily measured in air and removed from the viscosity measurements.



	5W30	10W40	SAE60
Density (60 F)	0.876 kg/l	0.8713 kg/l	0.8931 kg/l
Viscosity 40C	57.2 cSt	109.7 cSt	293.4 cSt
Viscosity 100C	10.5-11.2cSt	14.0 cSt	24.0 cSt
Viscosity Index	176	146	104

Effect of Temperature on Natural Vibration Frequency

Change in dimensions (thermal expansion coefficient) and young modulus will change the resonant frequency of the vibrating plate.

This effect is linear.

$$f_{ij} = \frac{\lambda_{ij}^2}{2\pi a^2} \left[\frac{Eh^3}{12\gamma(1-\nu^2)} \right]^{1/2}$$

λ – function (boundary conditions, a/b)

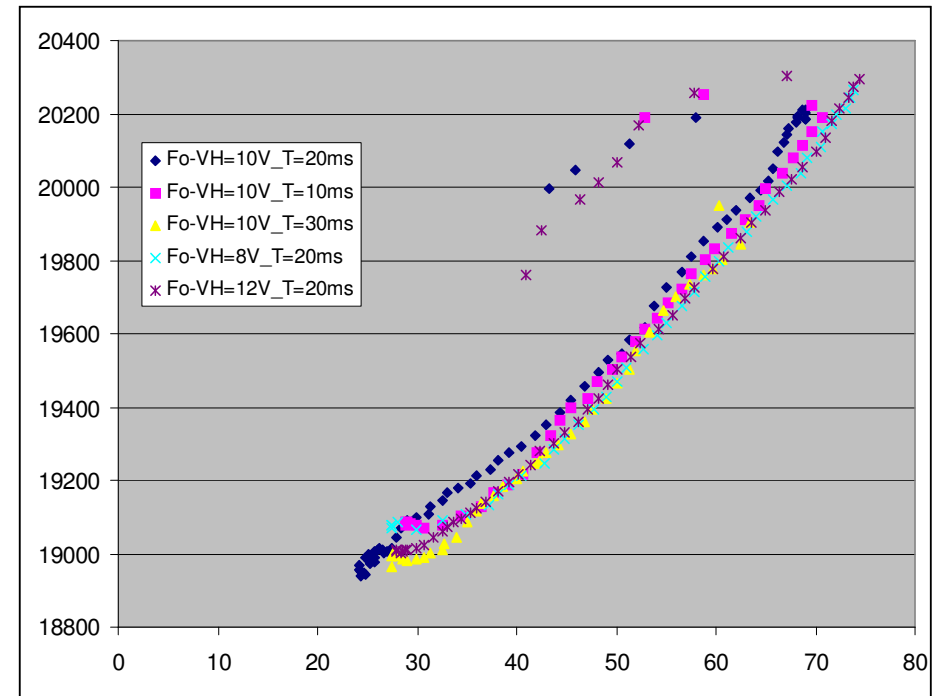
E – Young's modulus

h – plate thickness

γ – mass per unit area of plate

a – length of plate

ν – Poisson's ratio



Heat pulse time and amplitude have no effect on frequency of vibration.

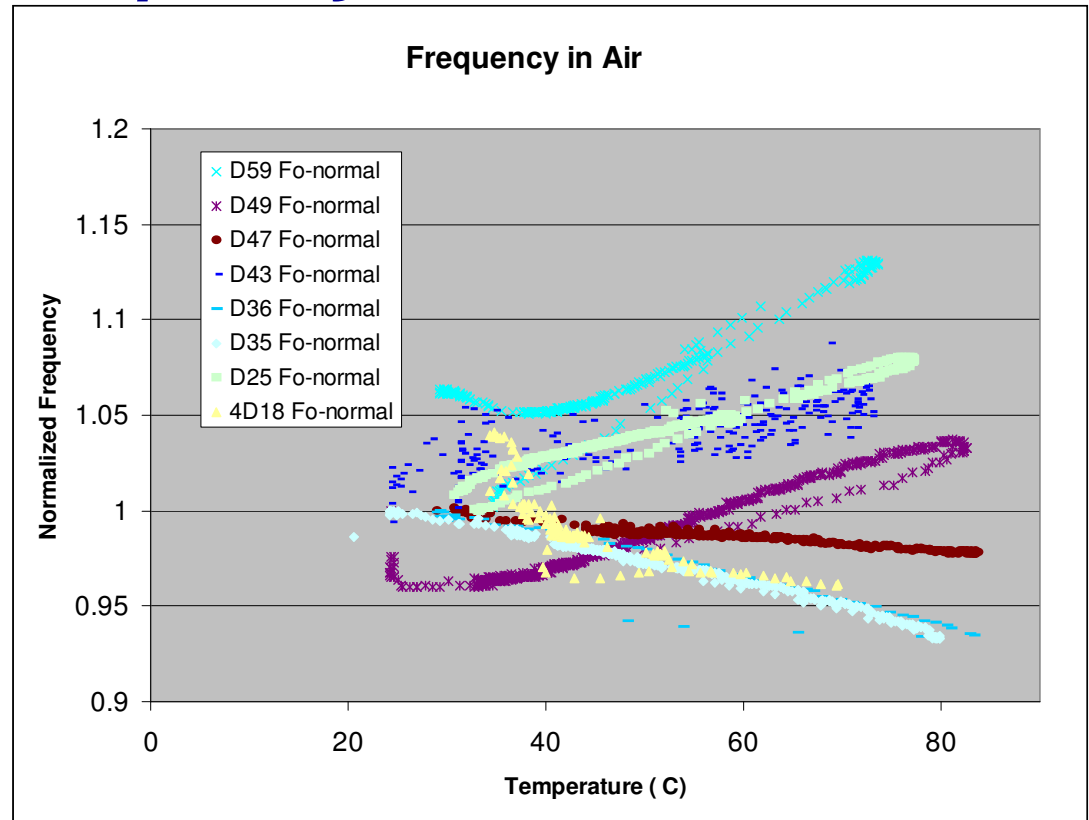
They affect the amplitude of vibration but not the frequency. Designed plates have different material compositions.

Effect of Temperature on Natural Vibration Frequency

$$f_{ij} = \frac{\lambda_{ij}^2}{2\pi a^2} \left[\frac{Eh^3}{12\gamma(1-\nu^2)} \right]^{1/2}$$

• Higher frequencies due to Poly, Passivation and Metal layers lead to a negative temperature dependence (E dominated). F_o decreases with T .

• Lower frequencies, without Pass and Metal, are geometry dominated (h^3, a^2). F_o increases with T .



ID	Device	Heater	Piezo	Size	Rheater	Pass	Metal	Fo	Q/cycles	Amp(mV)	UP/DOWN	Slope Norm
35	P_2.5_0.16_No_PASS_Yes_MTL	P	Poly	2.5	16%	No	Yes	23724	5	2	DOWN	-1.20E-03
36	P_2.5_0.02_No_PASS_Yes_MTL	P	Poly	2.5	2%	No	Yes	20922	31	5	DOWN	-1.17E-03
47	Poly_2.5_0.16_No_PASS_No_MTL	Poly	Poly	2.5	16%	No	No	23616	62	10	DOWN	-3.30E-04
43	Poly_2.5_0.35_Yes_PASS_No_MTL	Poly	Poly	2.5	35%	Yes	No	21042	7	4	DOWN	-8.75E-04
4D18	Poly_2.5_0.02_No_PASS_No_MTL	Poly	Poly	2.5	2%	No	No	16440	100	20	DOWN	-1.90E-03
25	Poly/P+_2.5_0.35_No_PASS_Yes_MTL	Poly	P+	2.5	35%	No	Yes	18660	80	250	UP	1.39E-03
49	P_2.5_0.02_No_PASS_No_MTL	P	Poly	2.5	2%	No	No	14505	49	5	UP	1.52E-03
59	Poly_2.5_0.35_No_PASS_Yes_MTL	Poly	Poly	2.5	35%	No	Yes	16997	60	15	UP	1.94E-03

Oil testing

Temperature of 10W40 oil is increased as the frequency, amplitude and Q of the sensor is measured.

$$f_{ij} = \frac{\lambda_{ij}^2}{2\pi\alpha^2} \left[\frac{Eh^3}{12\gamma(1-\nu^2)} \right]^{1/2}$$

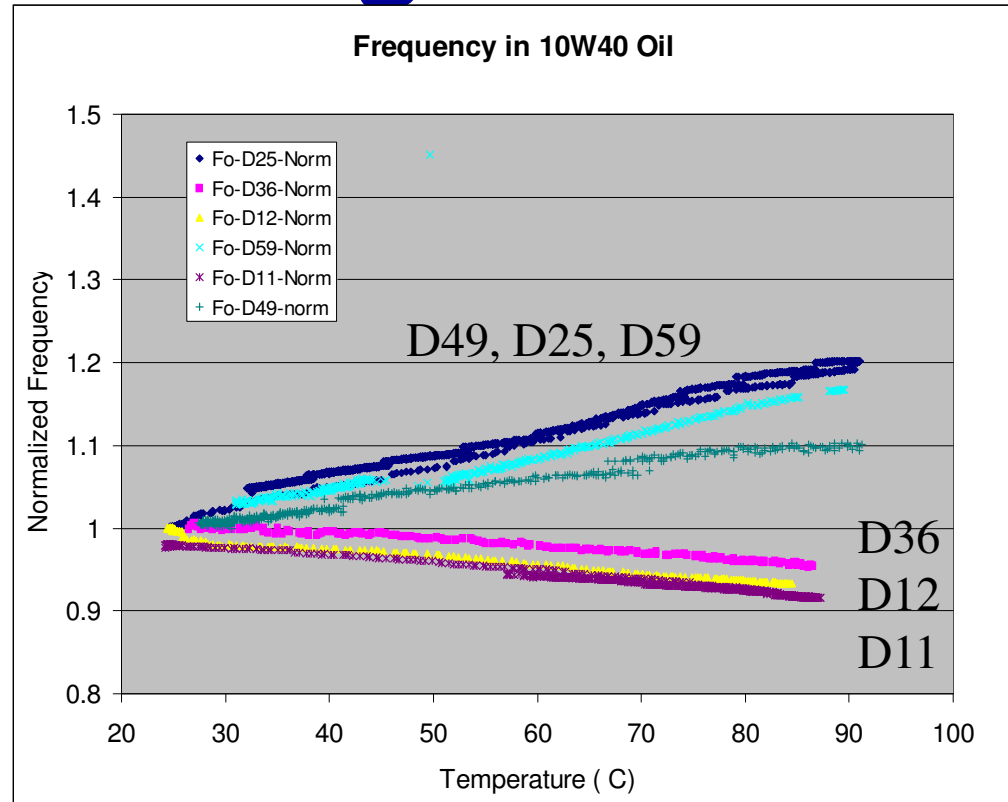
$$\omega_{fluid} = \frac{\omega_{vacuum}}{\sqrt{1+\beta}}$$

$$\beta = 0.6538 \frac{\rho_{fluid} a}{\rho_{plate} h} (1 + 1.082\xi) \quad \xi = \sqrt{\frac{\nu}{\omega a^2}}$$

$$Q = 2\pi \frac{\text{energy stored}}{\text{energy dissipated per cycle}} \approx \frac{0.95}{\xi}$$

ν - kinematic viscosity

ρ - density



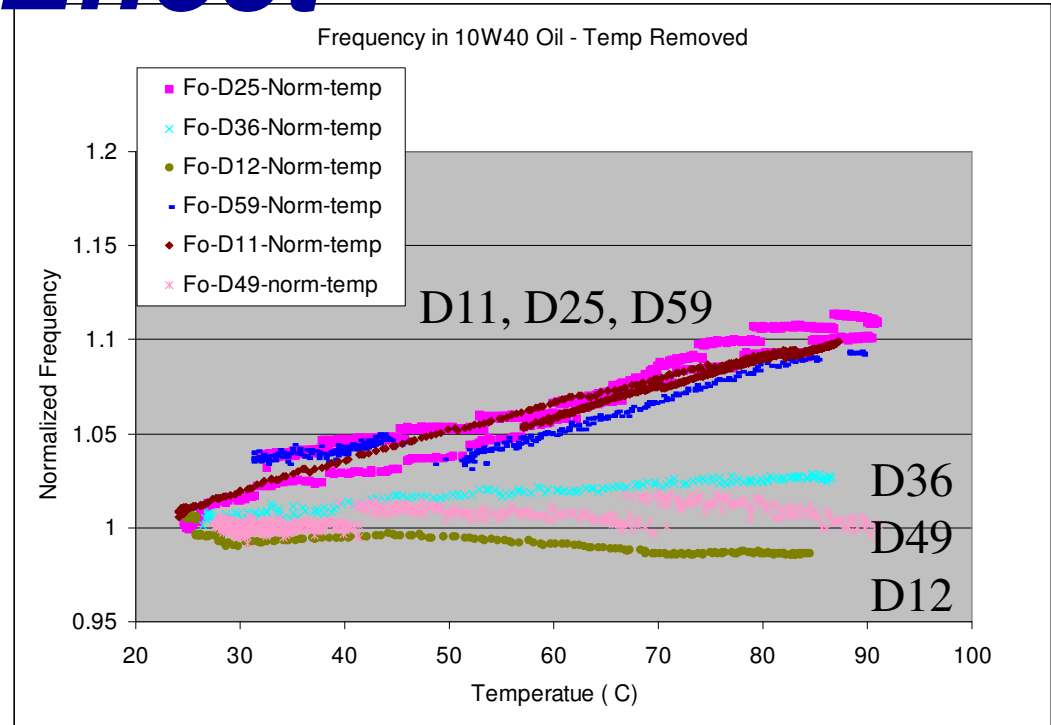
Temperature
Density
Viscosity

Removing Temperature Effect

Effect of Temperature is removed.

Devices with 2% heater show very small variation when effect of Temperature is removed.

D11, D25 and D59 show similar slopes.



Density and Viscosity

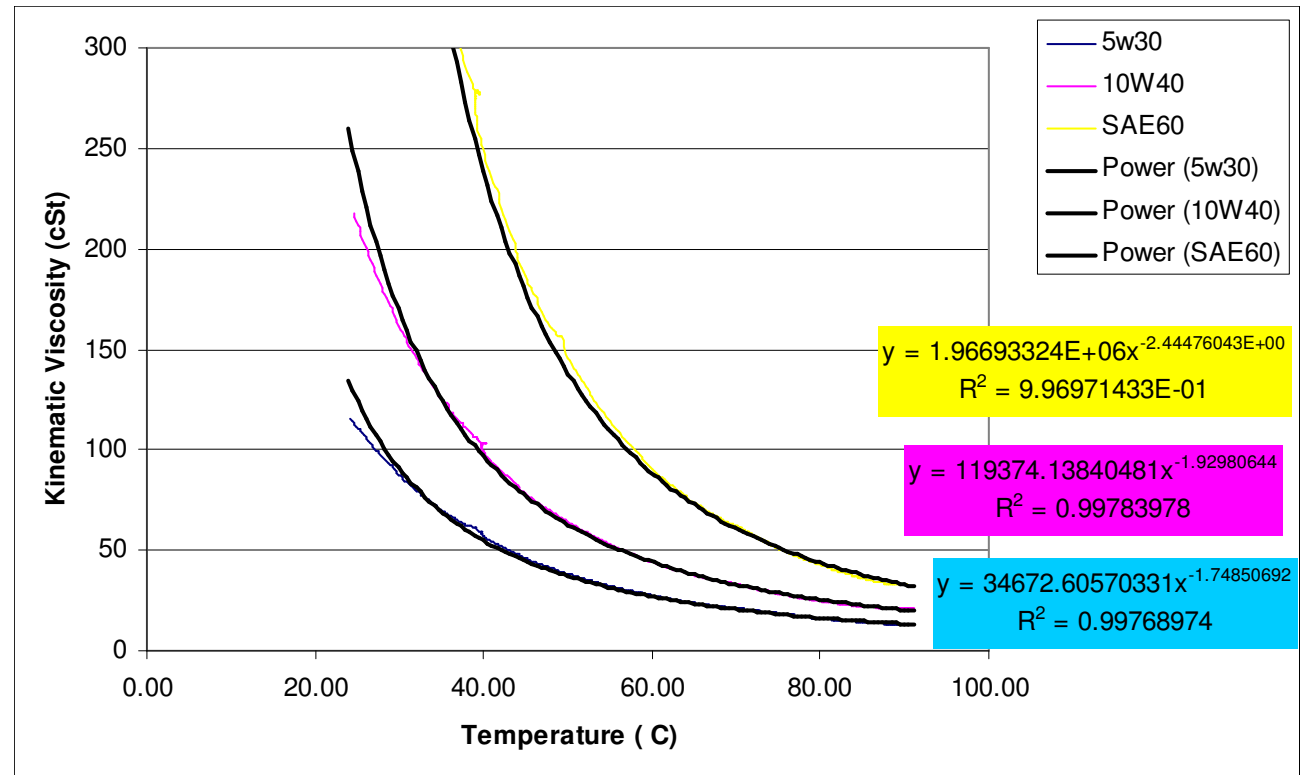
ID	Device	Heater	Piezo	Size	Rheater	Pass	Metal	P_M	Fo	Q/cycles	Amp(mV)
11	P_2.5_0.16_Yes_PASS_Yes_MTL	P	Poly	2.5	16%	Yes	Yes	Yes_Yes	22880	25	10
12	P_2.5_0.02_Yes_PASS_Yes_MTL	P	Poly	2.5	2%	Yes	Yes	Yes_Yes	27250	20	10
36	P_2.5_0.02_No_PASS_Yes_MTL	P	Poly	2.5	2%	No	Yes	No_Yes	20922	31	5
25	Poly/P+_2.5_0.35_No_PASS_Yes_MTL	Poly	P+	2.5	35%	No	Yes	No_Yes	18660	80	250
49	P_2.5_0.02_No_PASS_No_MTL	P	Poly	2.5	2%	No	No	No_No	14505	49	5
59	Poly_2.5_0.35_No_PASS_Yes_MTL	Poly	Poly	2.5	35%	No	Yes	No_Yes	16997	60	15

PIPING vs. KINEMATIC viscosity

Exponential fit to
experimental data.

Temperature of oil
can be converted to
kinematic viscosity.
Takes into account
change in density.

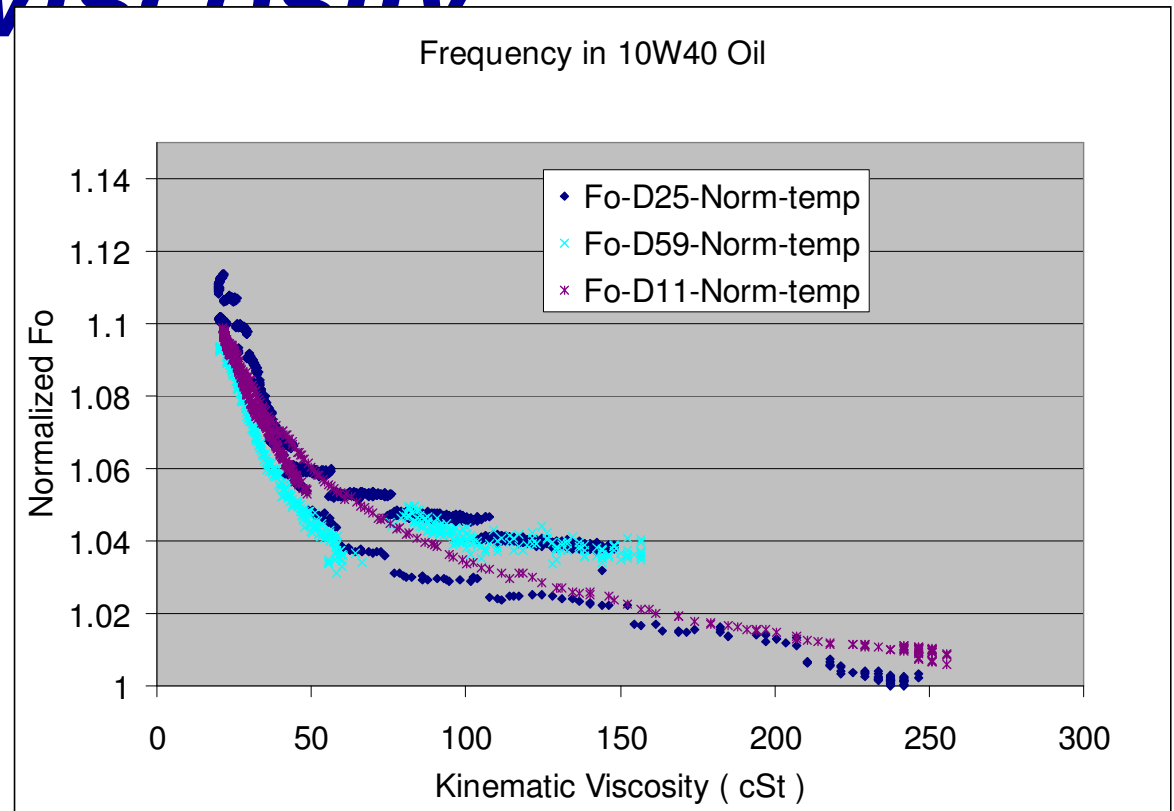
Best at low values.



Plotting vs. Kinematic viscosity

Similar results obtained with three different devices.

Error associated with Fo extraction algorithm and transient temperature effects.



Compare to theoretical

$$\omega_{fluid} = \frac{\omega_{vacuum}}{\sqrt{1 + \beta}}$$

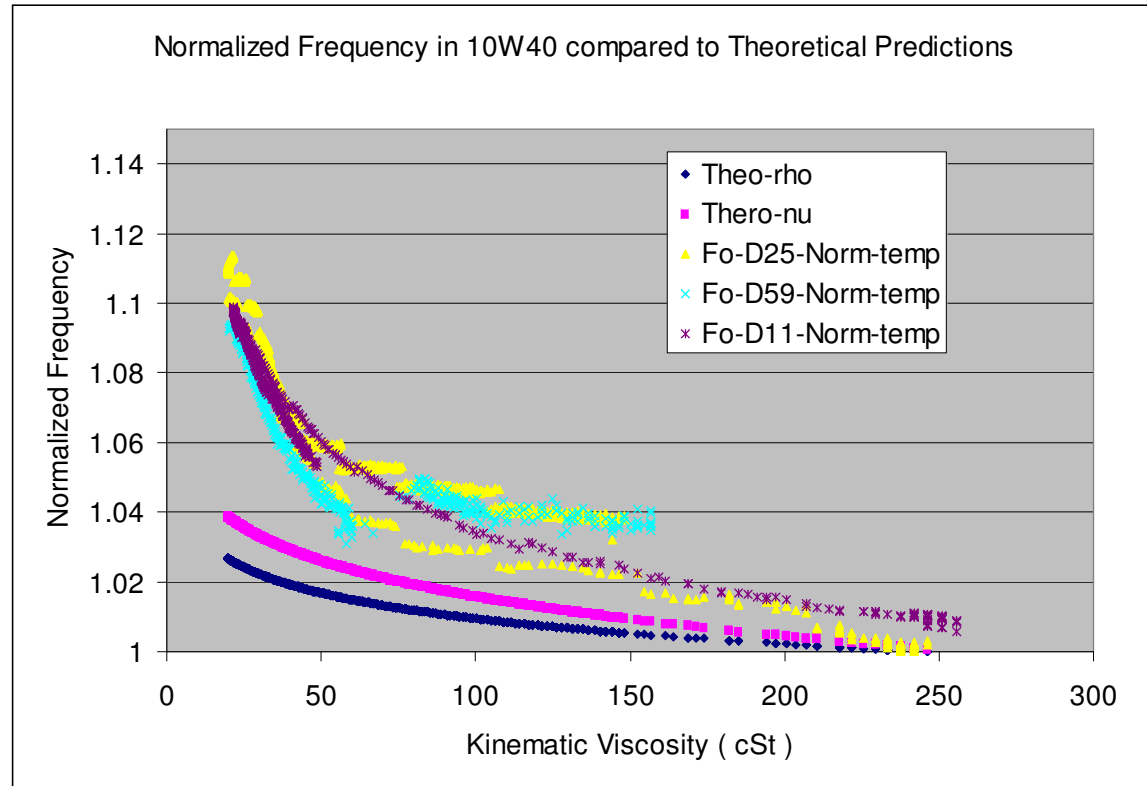
$$\beta = 0.6538 \frac{\rho_{fluid} a}{\rho_{plate} h} (1 + 1.082 \xi)$$

$$\xi = \sqrt{\frac{\nu}{\omega a^2}}$$

$$Q = 2\pi \frac{\text{energy_stored}}{\text{energy_dissipated_per_cycle}} \approx \frac{0.95}{\xi}$$

ν - kinematic viscosity

ρ - density



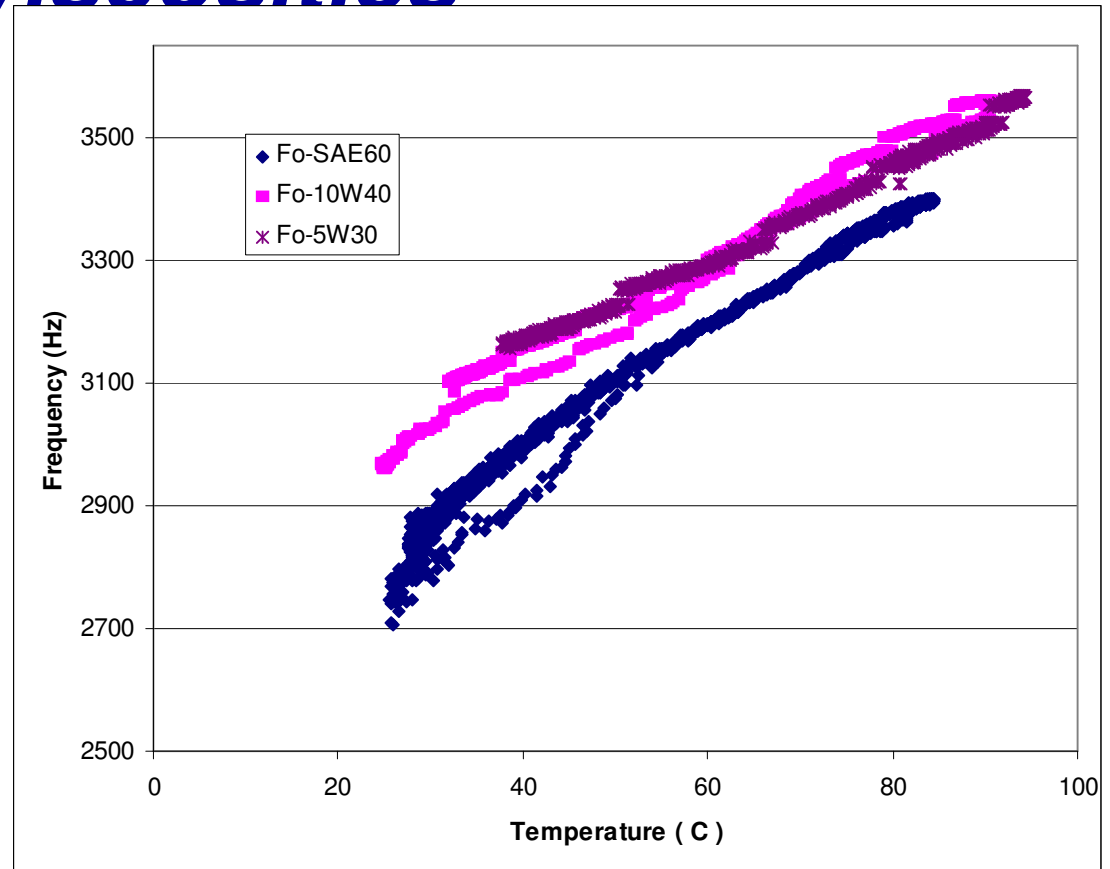
Testing in oils with different viscosities

Device D25 is placed in oils of different viscosities:

5W30, 10W40 and SAE60

Temperature of the oil is increased.

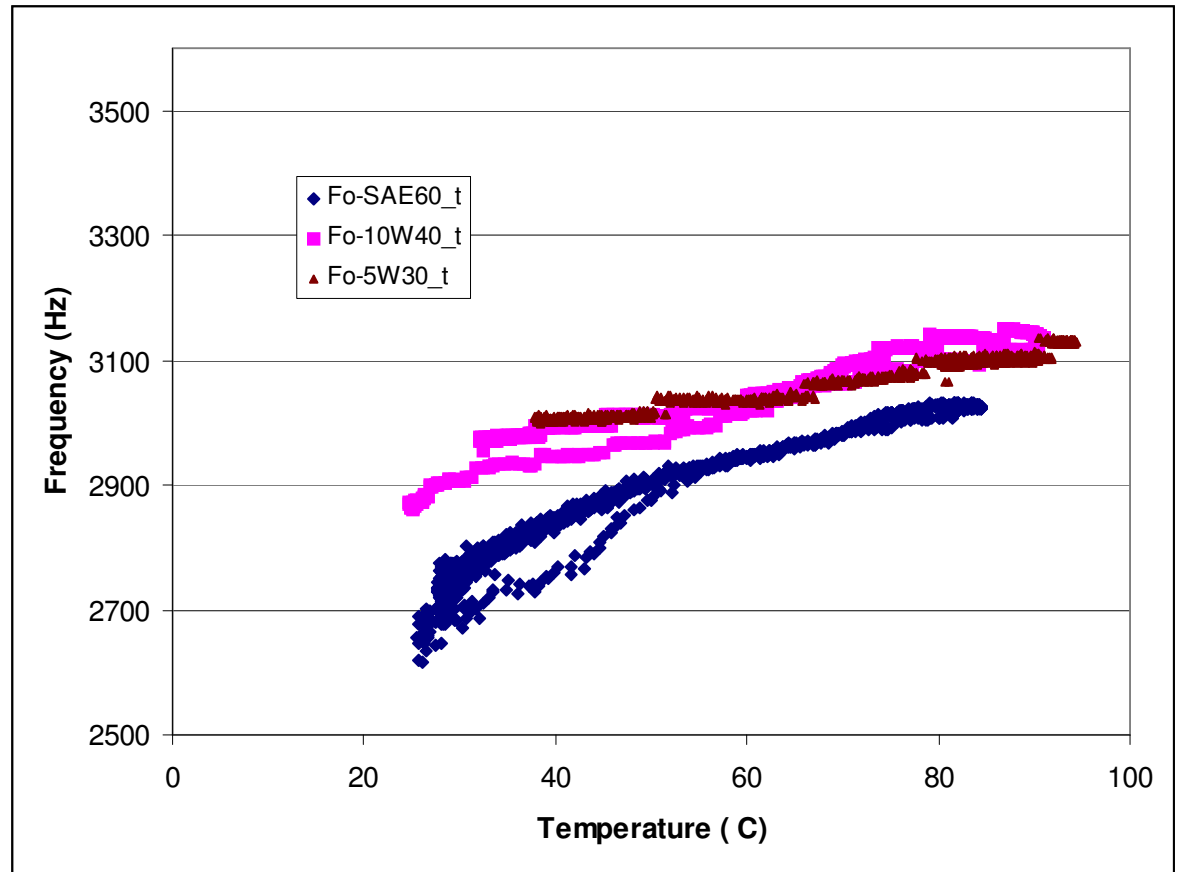
Frequency of resonance changes with the oil's temperature, density and viscosity.



Remove effect of temperature

The effect of temperature on the resonant frequency is removed with the data obtained with the device was tested in air.

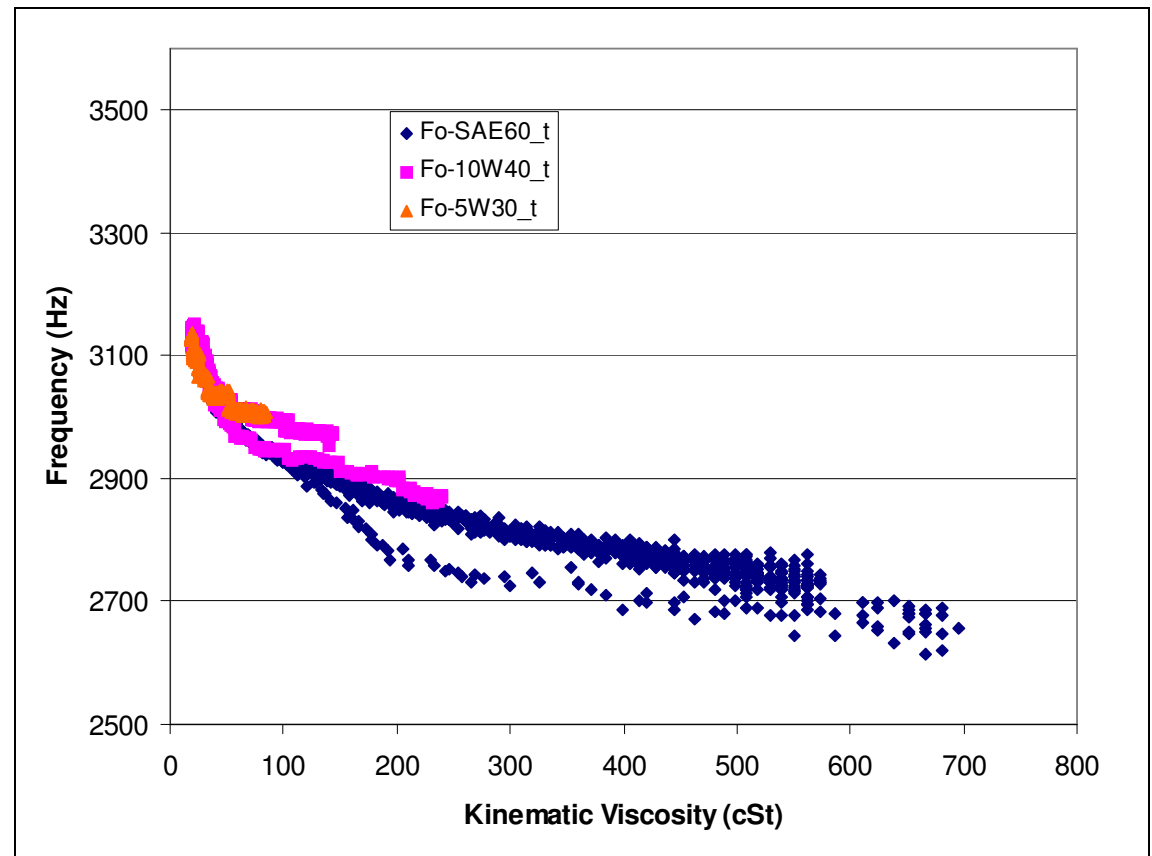
In this case the change in frequency is reduced by 0.13% / C due to this temperature effect.



Plot resonance frequency vs. viscosity

The data is plotted against kinematic viscosity. This takes into account the change in density that the oil experiences as the temperature is increased.

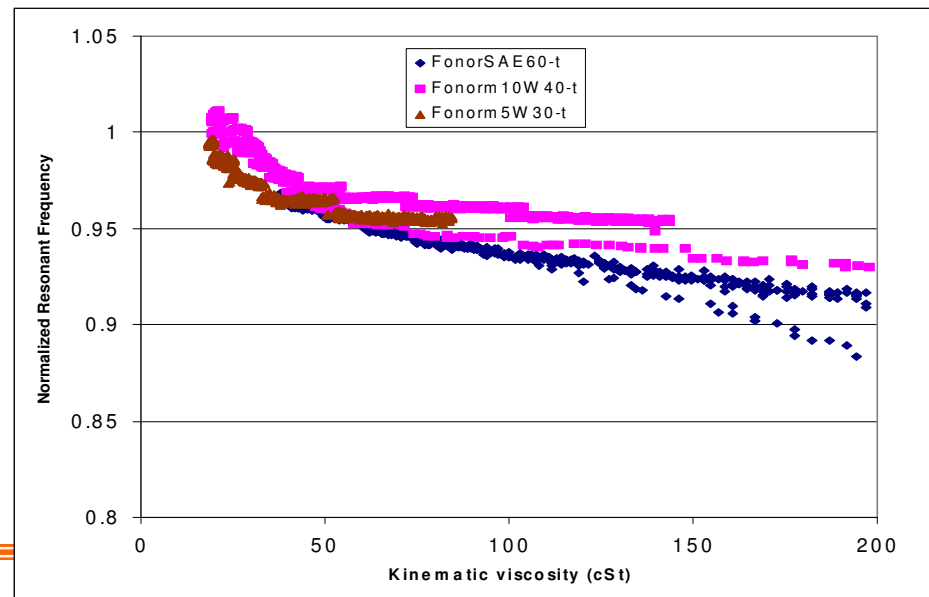
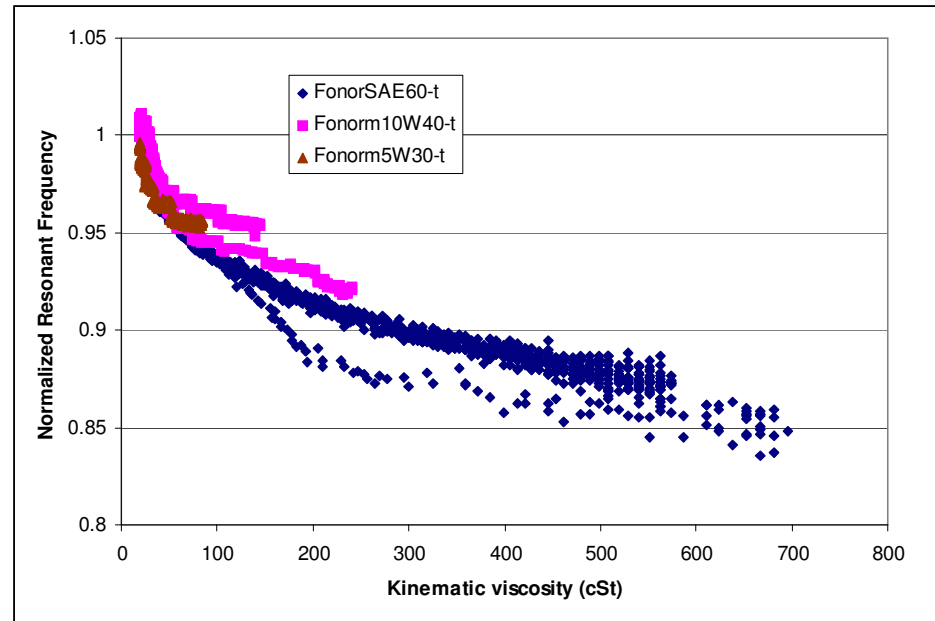
The proposed sensor measured kinematic viscosity as the oil is not only sheared but also displaced.



$$v = \frac{\eta}{\rho}$$

Normalize frequency

Normalized at 40 cSt so that all three oils have a common viscosity value.



Conclusion

- Successful fabrication of thermal resonator devices to measure viscosity.
- Improved understanding of factors affecting performance.
- Good sensitivity to viscosity.
- Further testing may improve sensitivity even further.

- JMEMS article under review. Requested more data to support claims.
- A second journal article in preparation.